

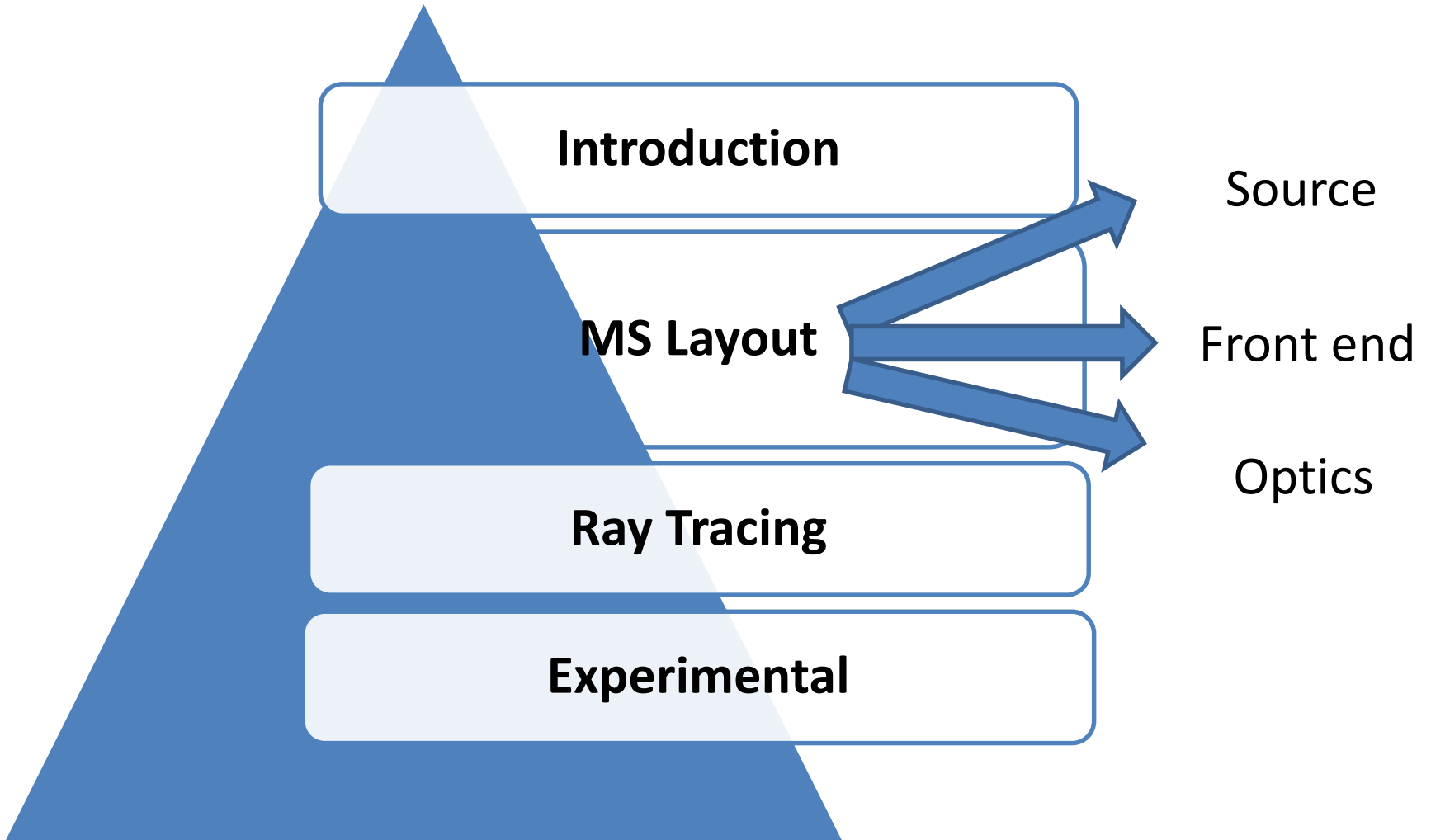
XVI International Conference  
on Science, Arts and Culture  
International Conference  
ON  
**SESAME**  
In Honour of Paolo Budinich  
29 August - 2 September 2016  
Veli Lošinj, Croatia



# SESAME Materials Science Beamline

Mahmoud Abdellatif, PhD  
Materials Science BL Scientist  
SESAME Synchrotron  
Jordan

# Outlines

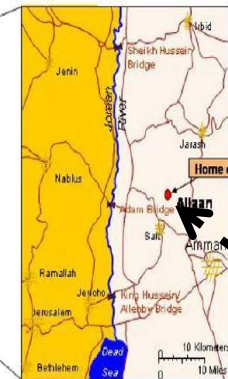
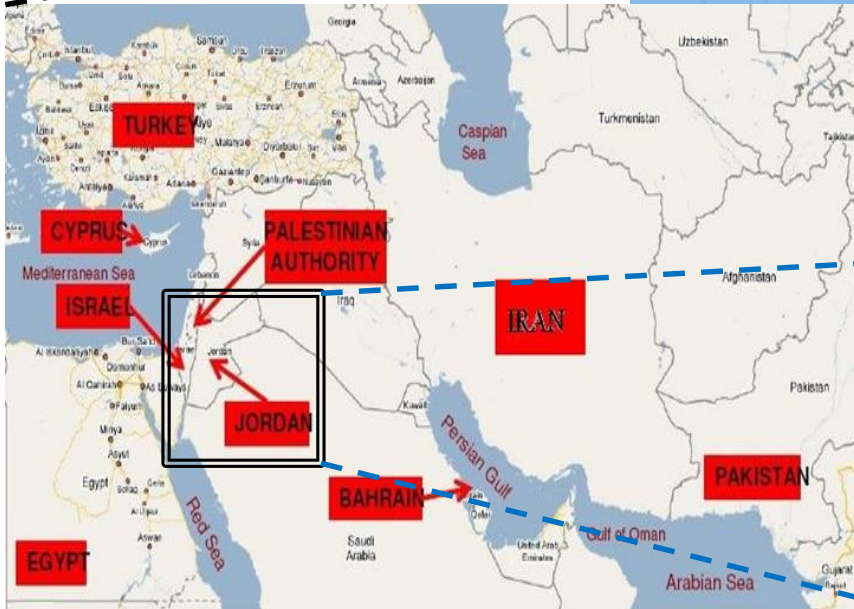
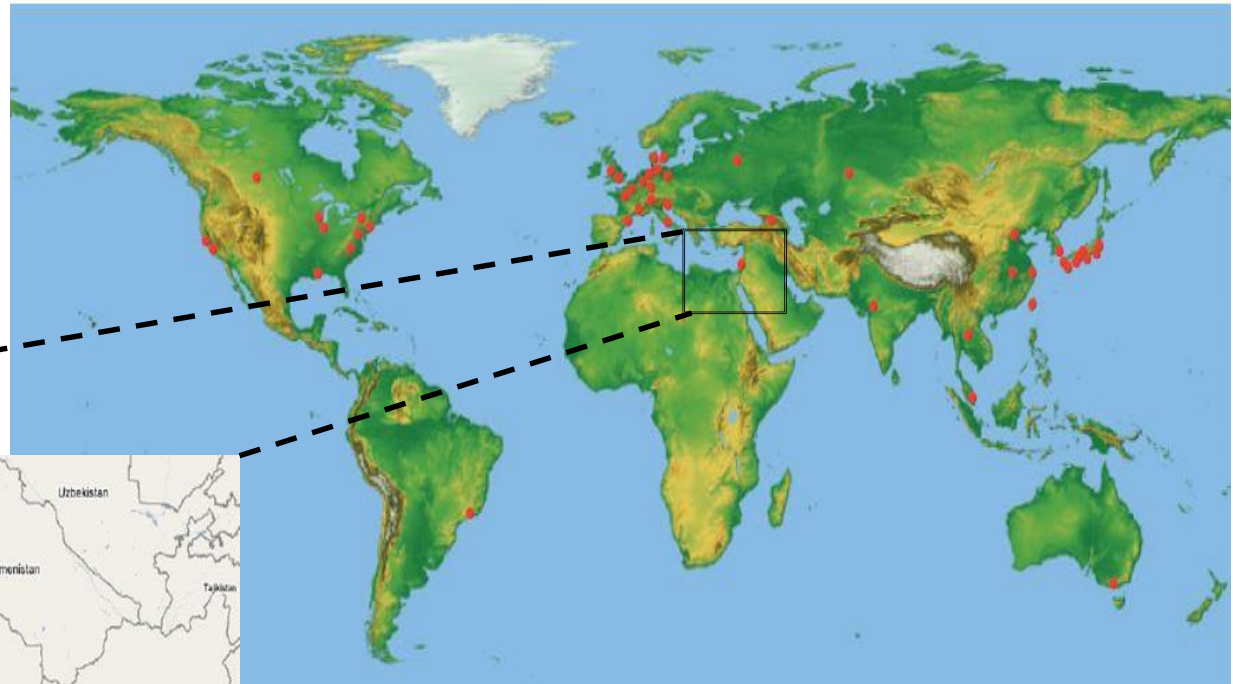


# SESAME Synchrotron

Synchrotron light for **E**xperimental **S**cience and **A**pplications in the **M**iddle **E**ast

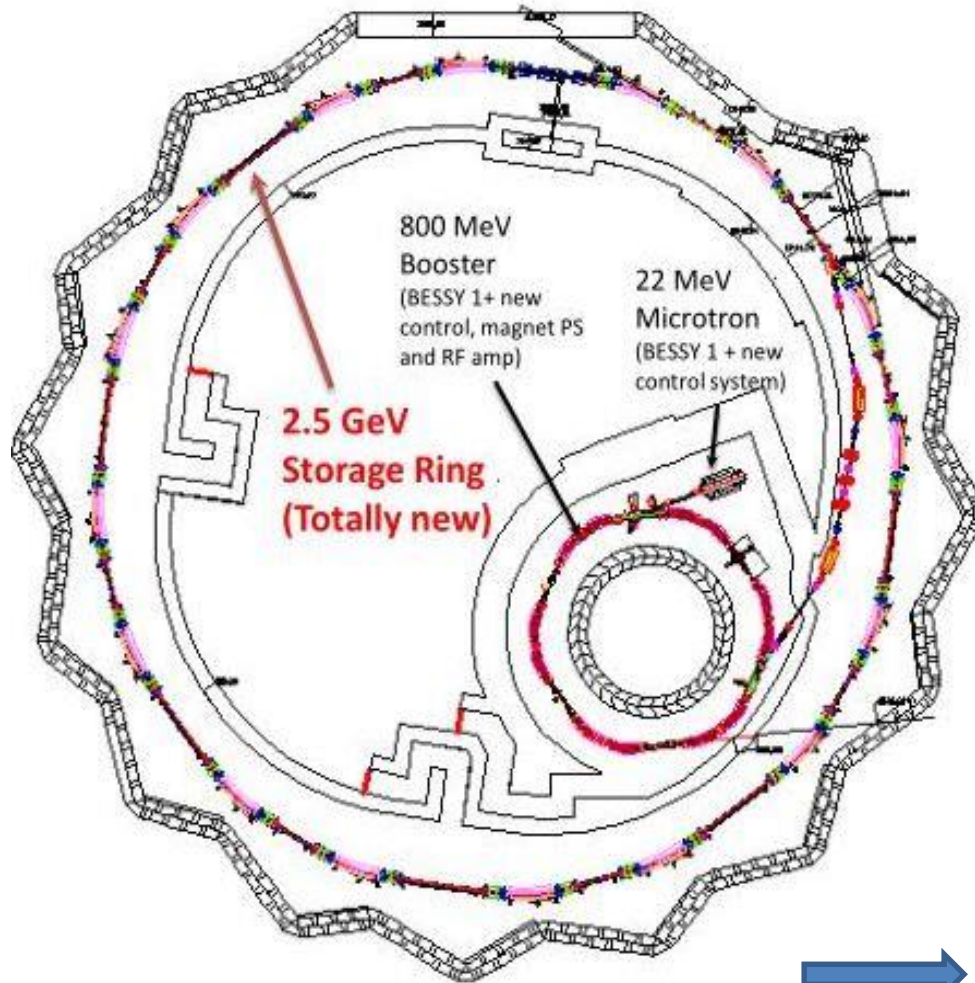
## SESAME observers

France, Germany, Greece,  
Italy, Japan, Kuwait,  
Portugal, Russian  
Federation, Sweden,  
Switzerland, UK, USA



We are  
here

# First beamlines



Energy (GeV)	2.5
Maximum Beam Current (mA)	400
Bending Flux Density (T)	1.455
Circumference (m)	133.2
Emittance (nm.rad)	26
Maximum ID Length (m)	3.9
Beam Cross Section in the Long Straight Sections ( $\sigma_x, \sigma_y$ ) ( $\mu\text{m}$ )	828 x 21
Available Straight Sections for Insertion Devices	12
Number of Bending Magnets	16
Number of Quadrupoles	64
Number of Sextupoles	64

Phase one beamlines

XAFS - XRF

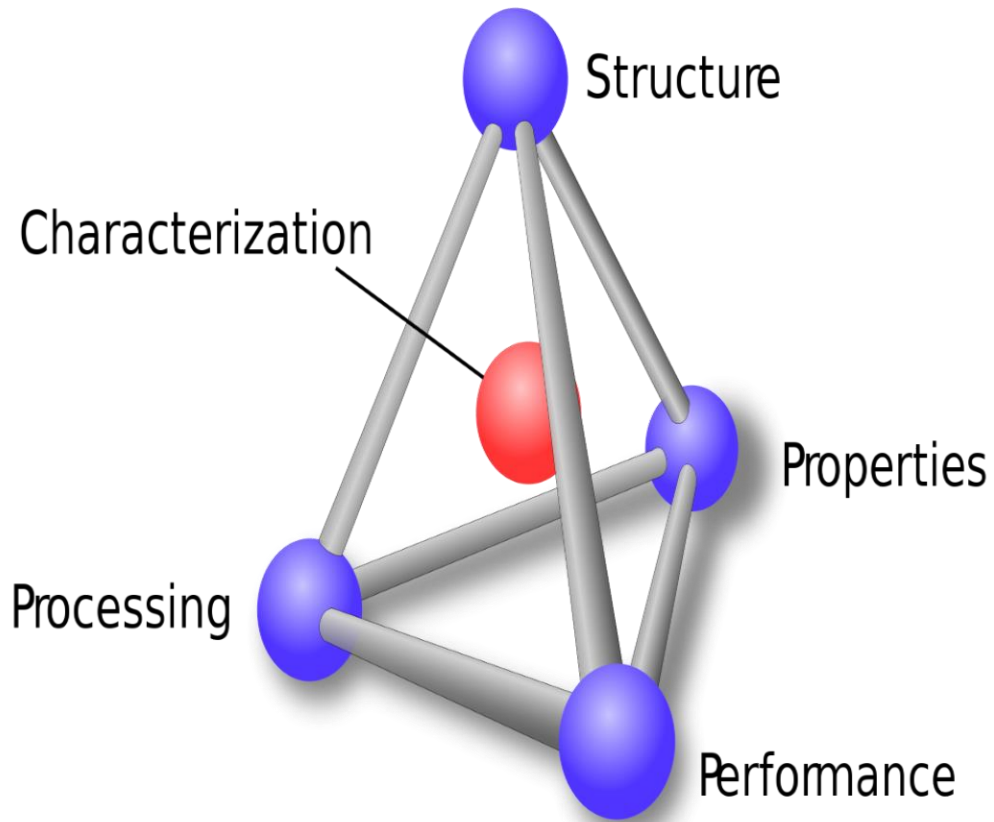
IR

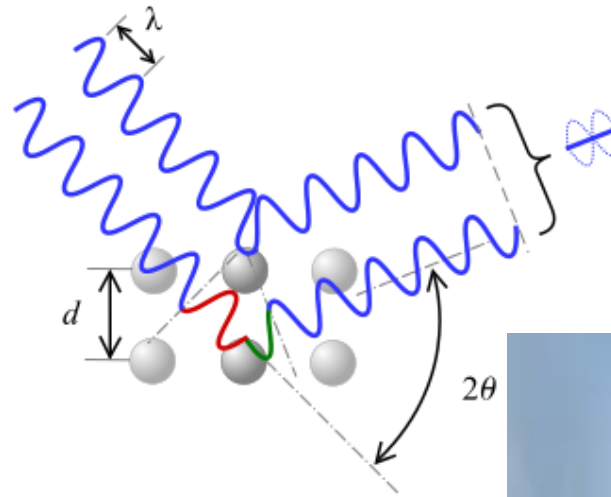
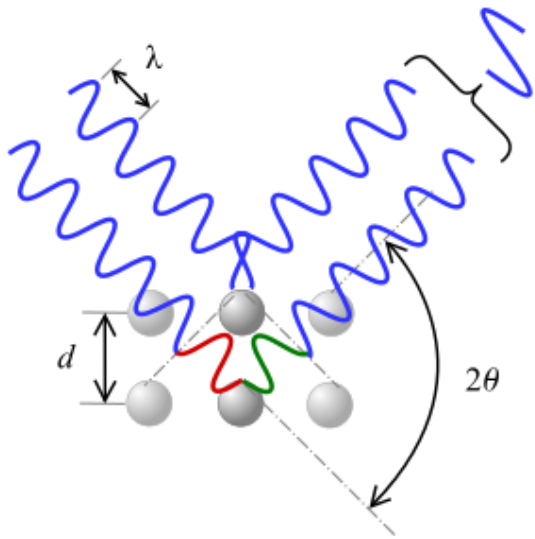
**Materials Science MS (XRD)**

MX (Macro Molecular XRD)

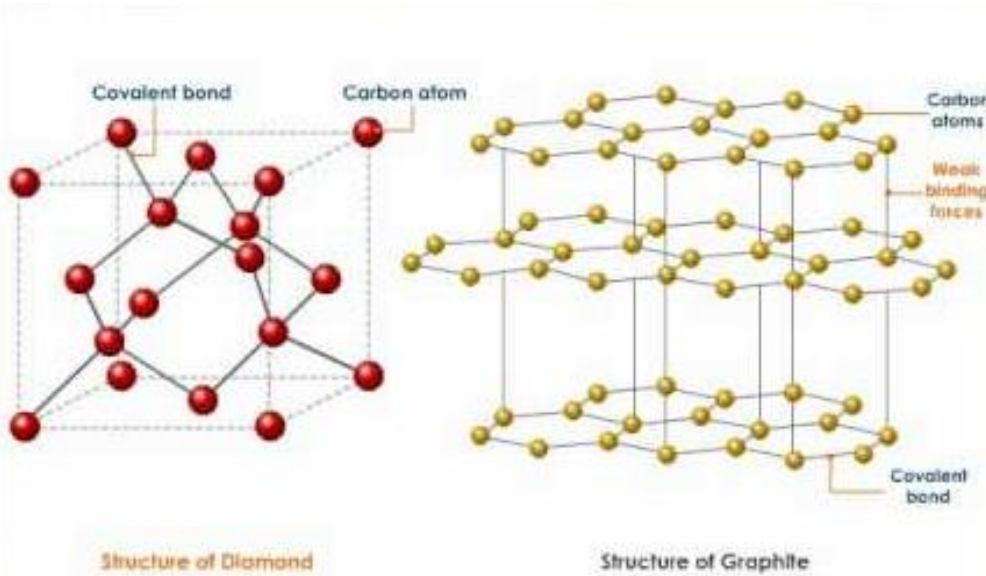


# What is MS beamline ?

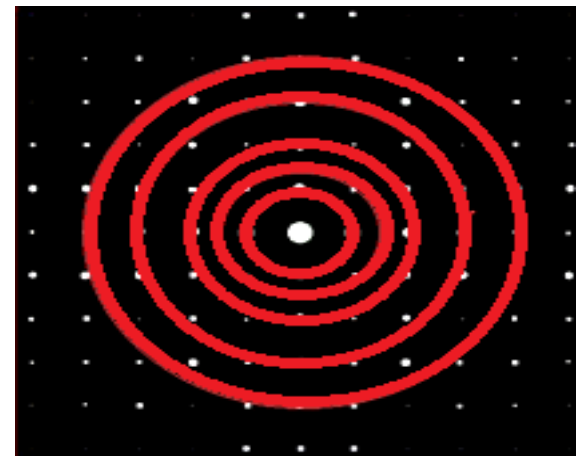
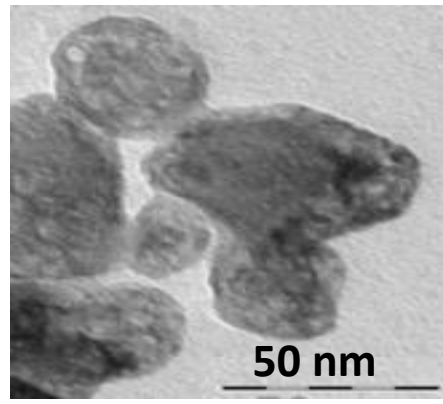
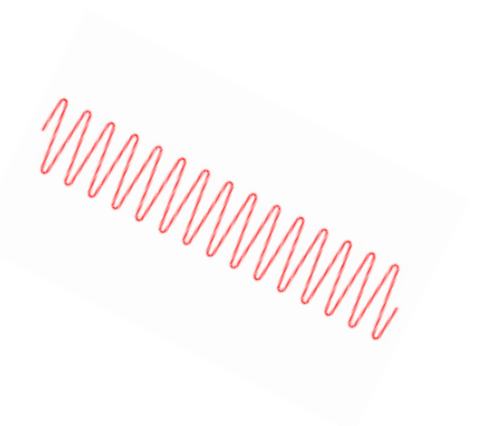
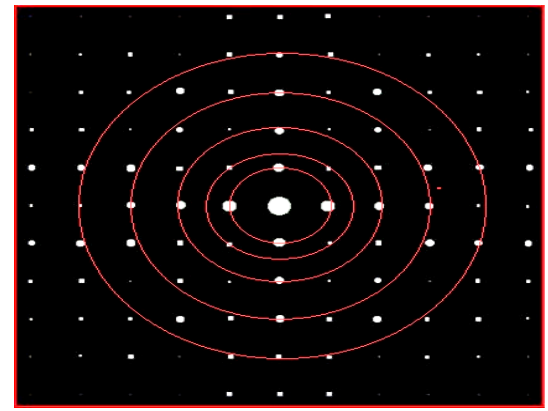
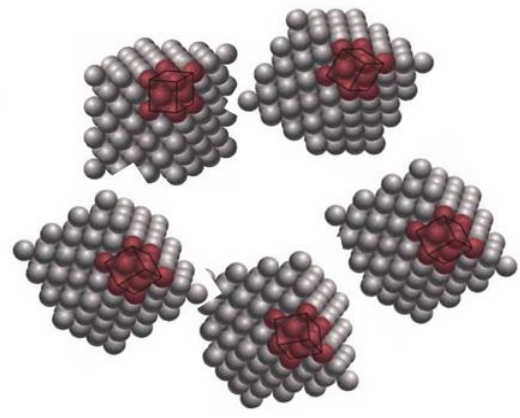
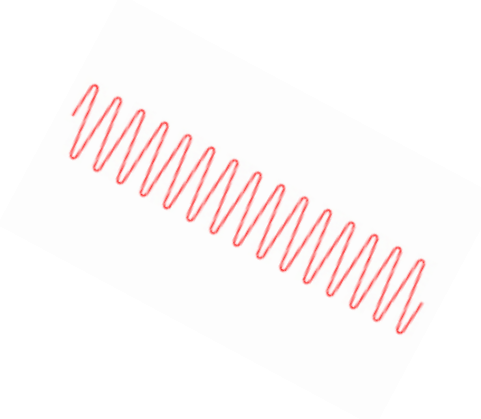
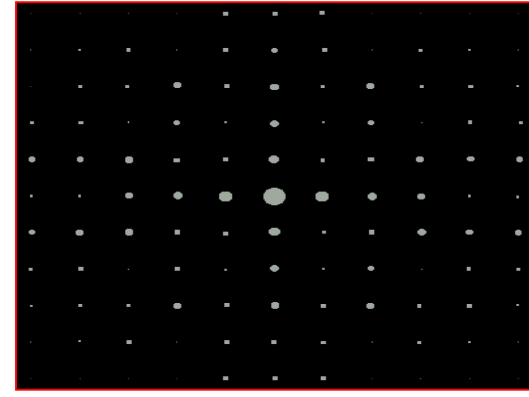
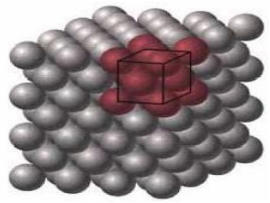
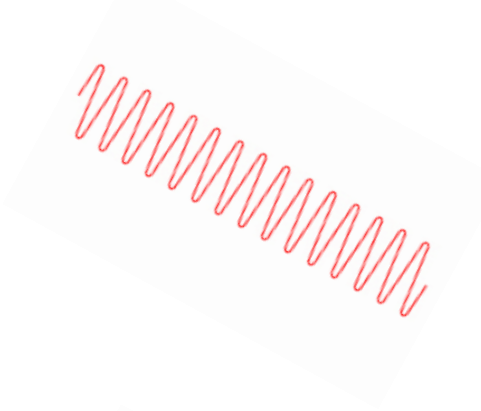




$$\lambda = 2 d_{hkl} \sin\theta_B$$



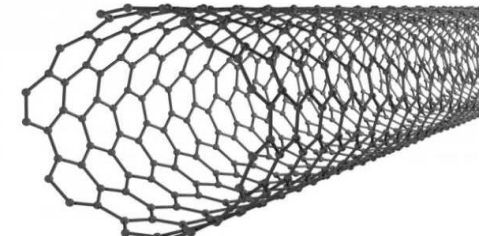
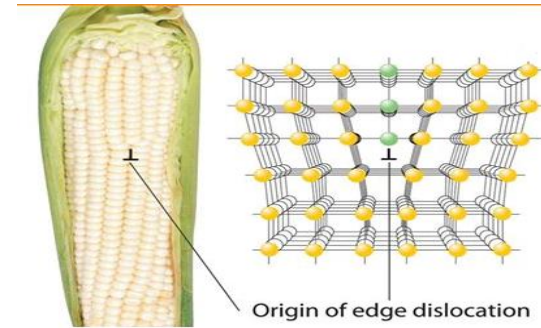
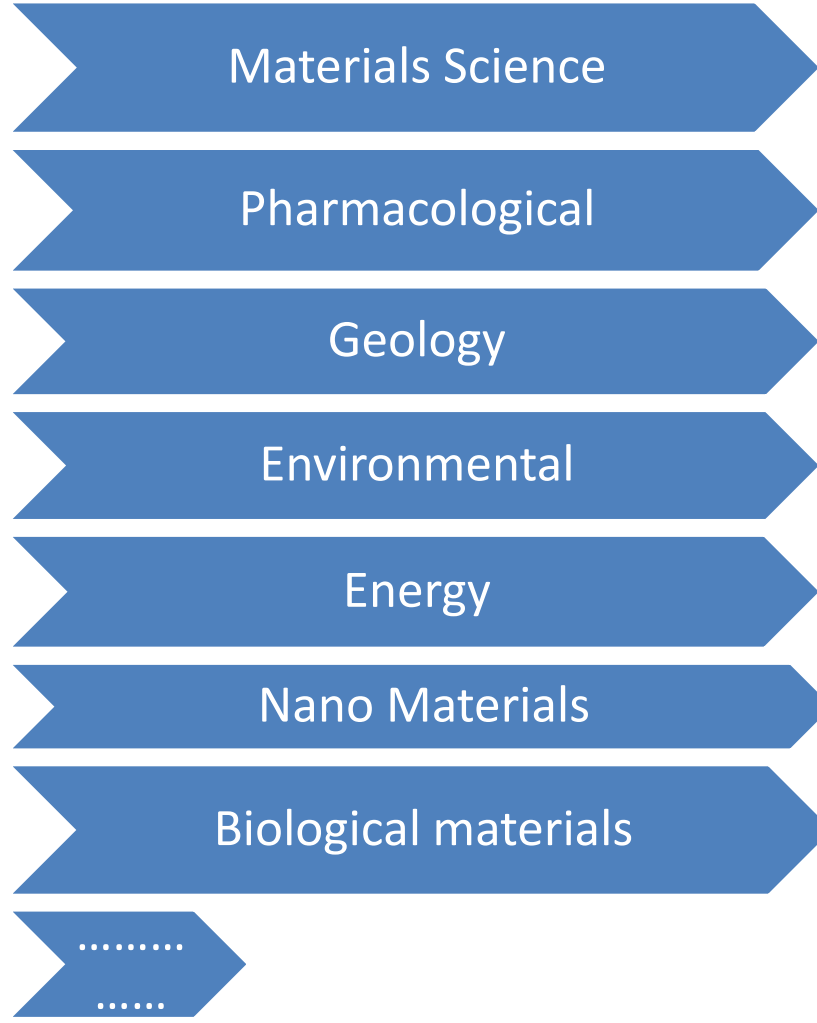
# Single – Poly – Nano



# XRD diffraction frequent uses



wiseGEEK





# Why do we need SR-XRD?

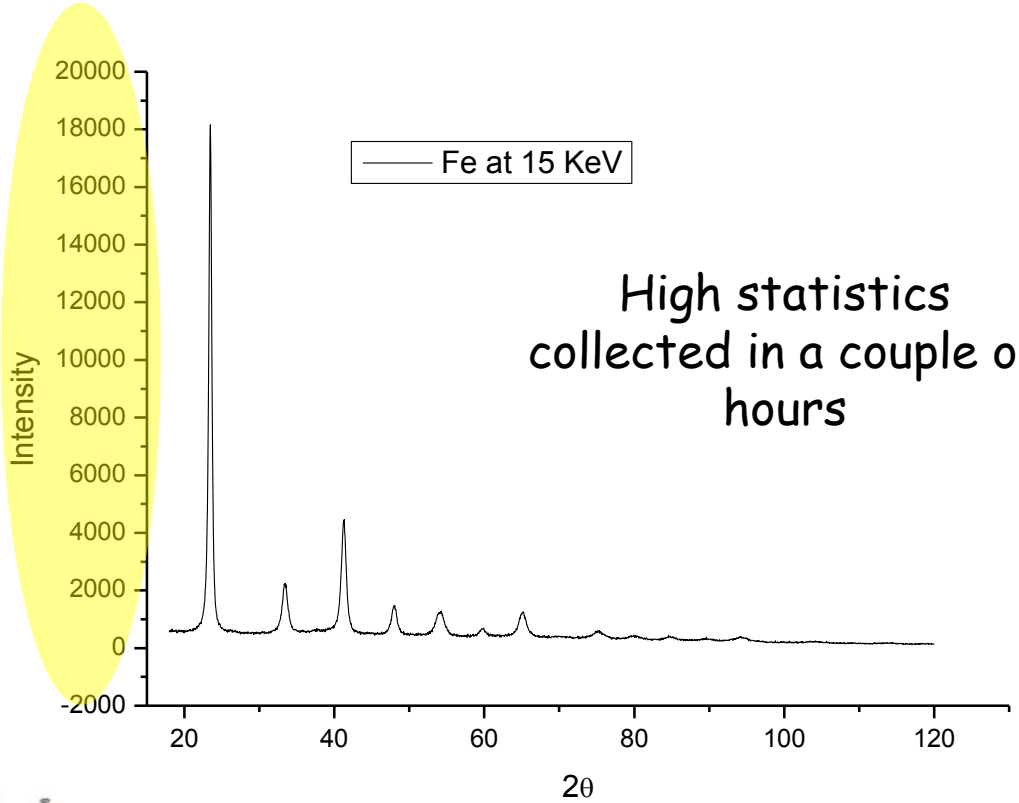
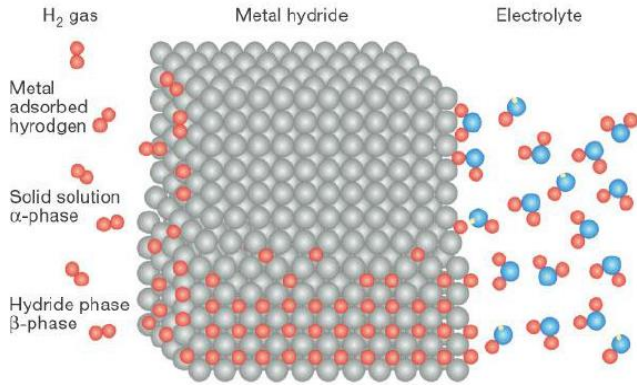
**“PHYSICS IS, HOPEFULLY, SIMPLE. PHYSICISTS ARE NOT.”**

**EDWARD TELLER**

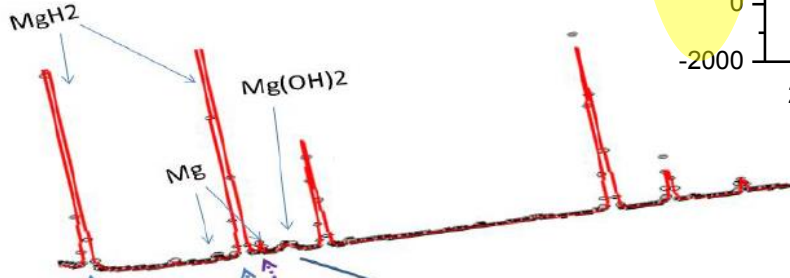


Think simple

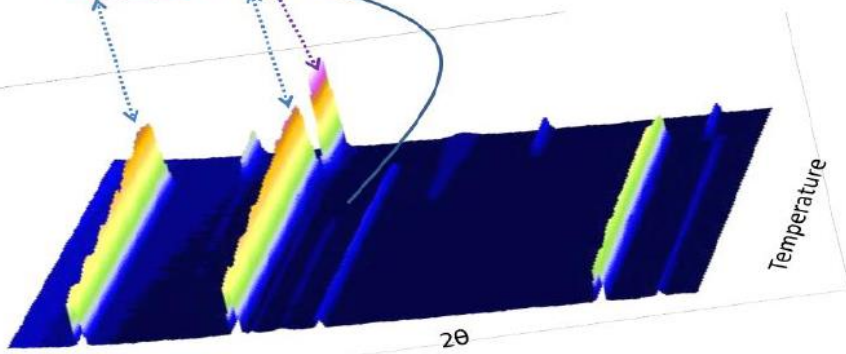
# 1. Brilliance (time and statistics , e.g. in-situ XRD)



High statistics collected in a couple of hours



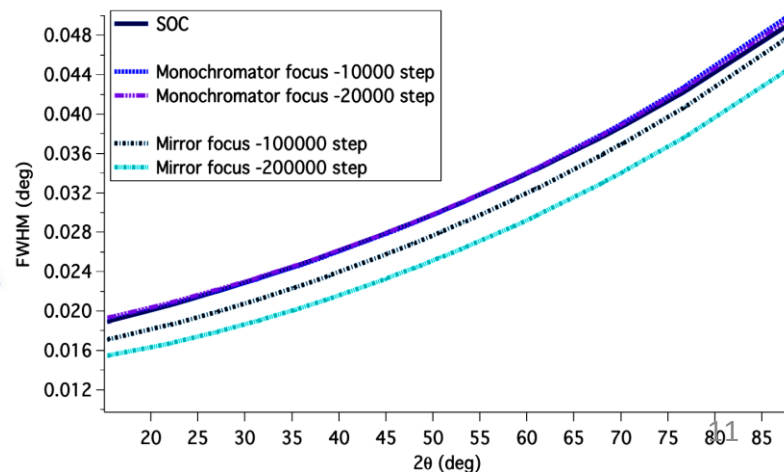
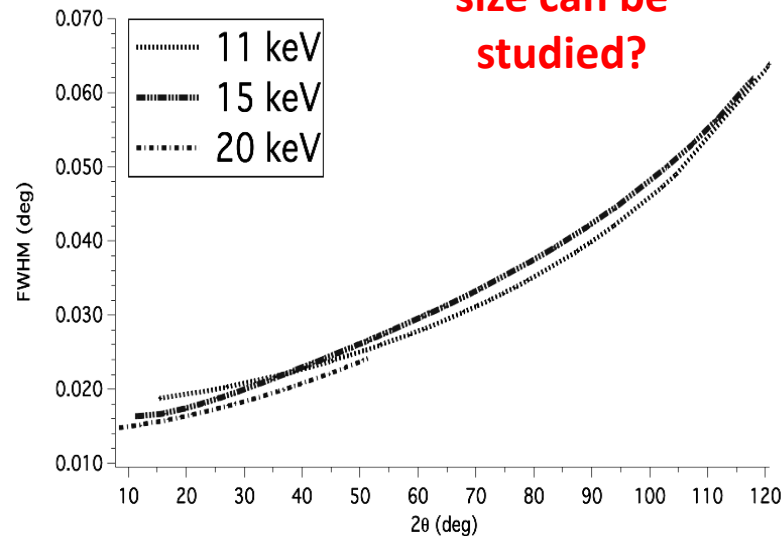
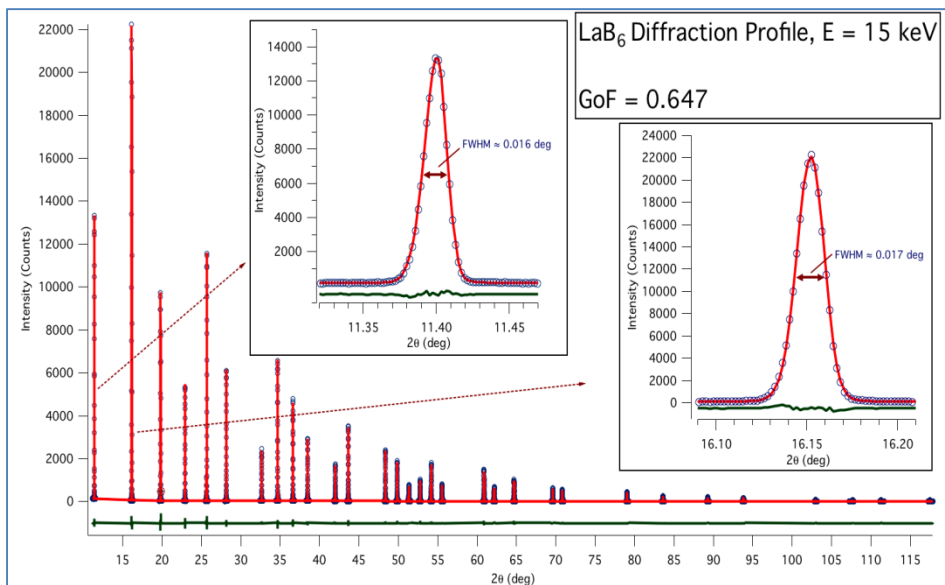
In situ XRD for hydrogen desorption kinetics



# 2. Instrumental resolution and instrumental profile

Diffraction pattern is a **sum** of two contributions:  
**Sample + Instrument**

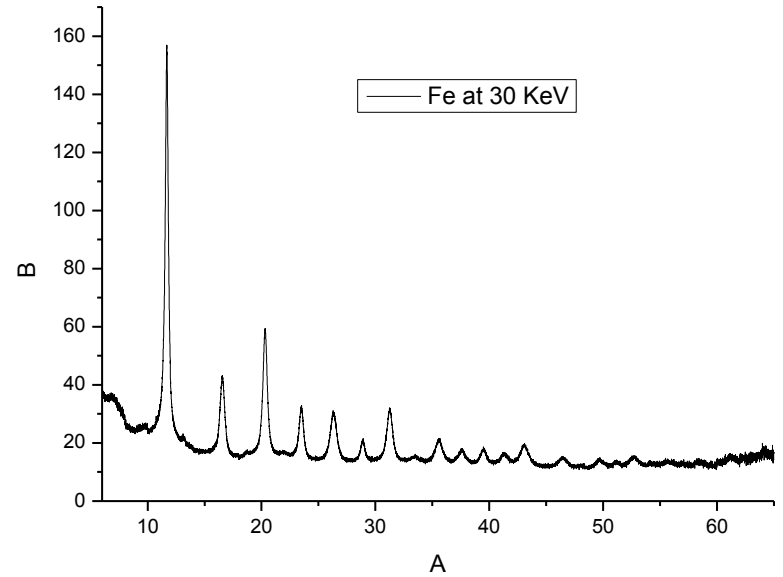
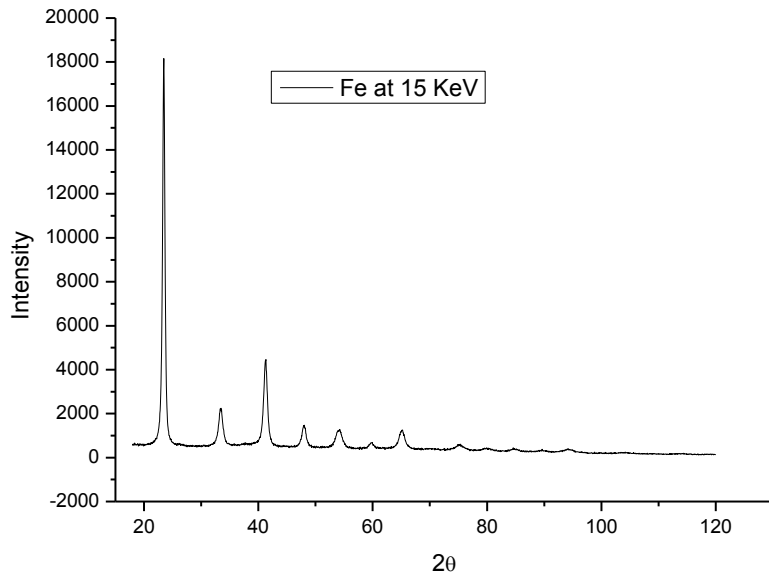
Maximum crystal size can be studied?



MCX: a synchrotron radiation beamline for X-ray diffraction Line Profile Analysis

Luca Rebuffi,<sup>\*,[a,b]</sup> Jasper R. Plaisier,<sup>[a]</sup> Mahmoud Abdellatif,<sup>[a]</sup> Andrea Lausi,<sup>[a]</sup> and Paolo Scardi<sup>[b]</sup>

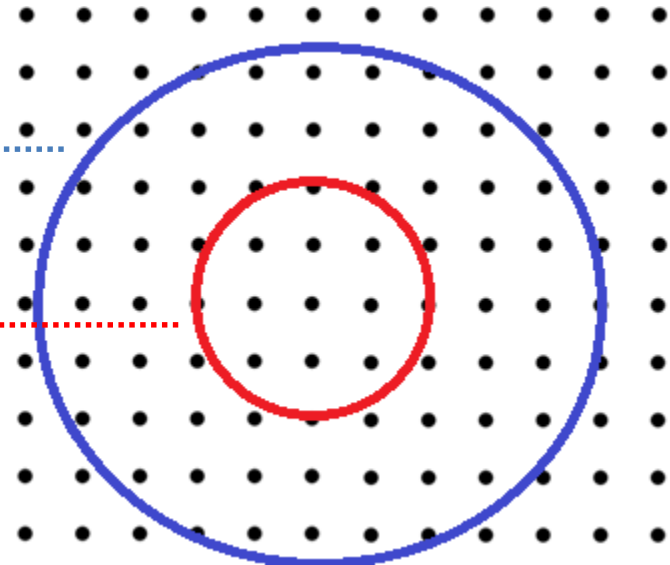
### 3. Larger limiting sphere (radius $1/\lambda$ )



Short  $\lambda$  for Pair  
distribution  
function PDF for  
amorphous

Shorter  $\lambda$

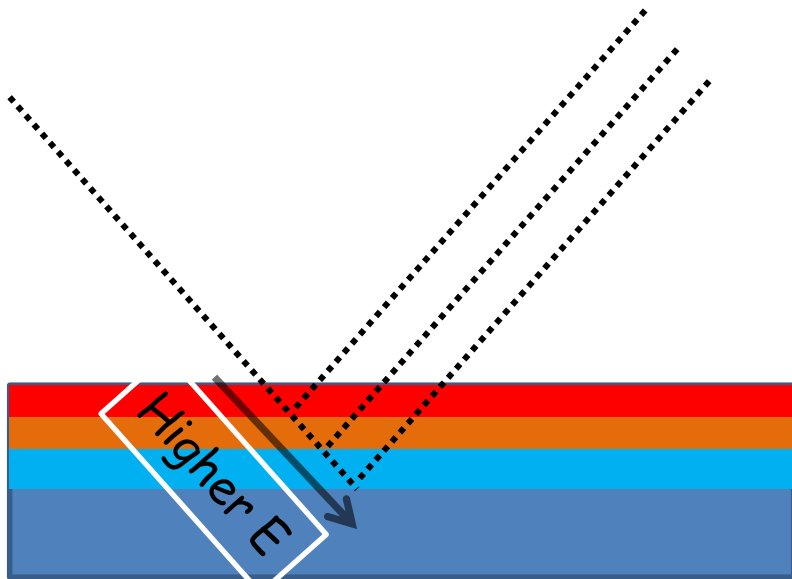
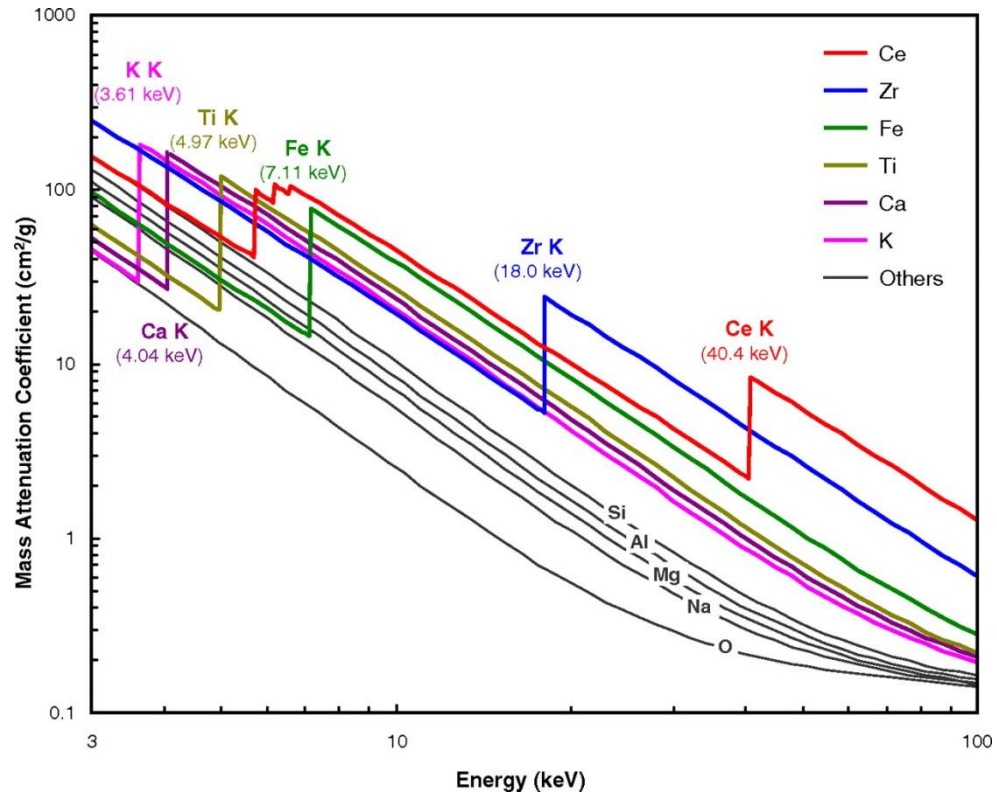
longer  $\lambda$





# 4. Energy selectivity

- Absorption edges
- resonant diffraction
- beam penetration depth



Higher energy get diffracts by deeper layers

# Outlines

**Introduction**

**MS Layout**

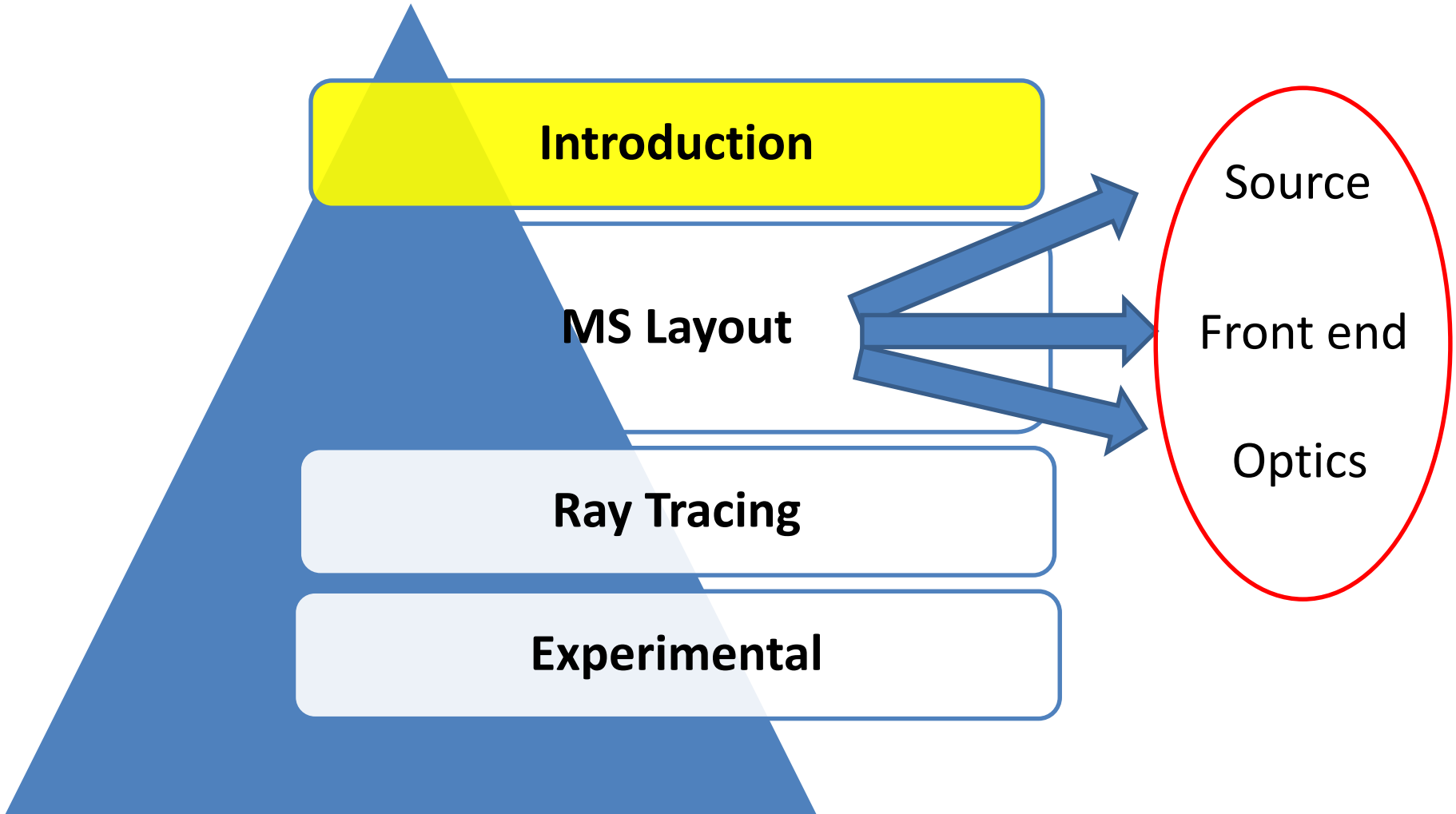
**Ray Tracing**

**Experimental**

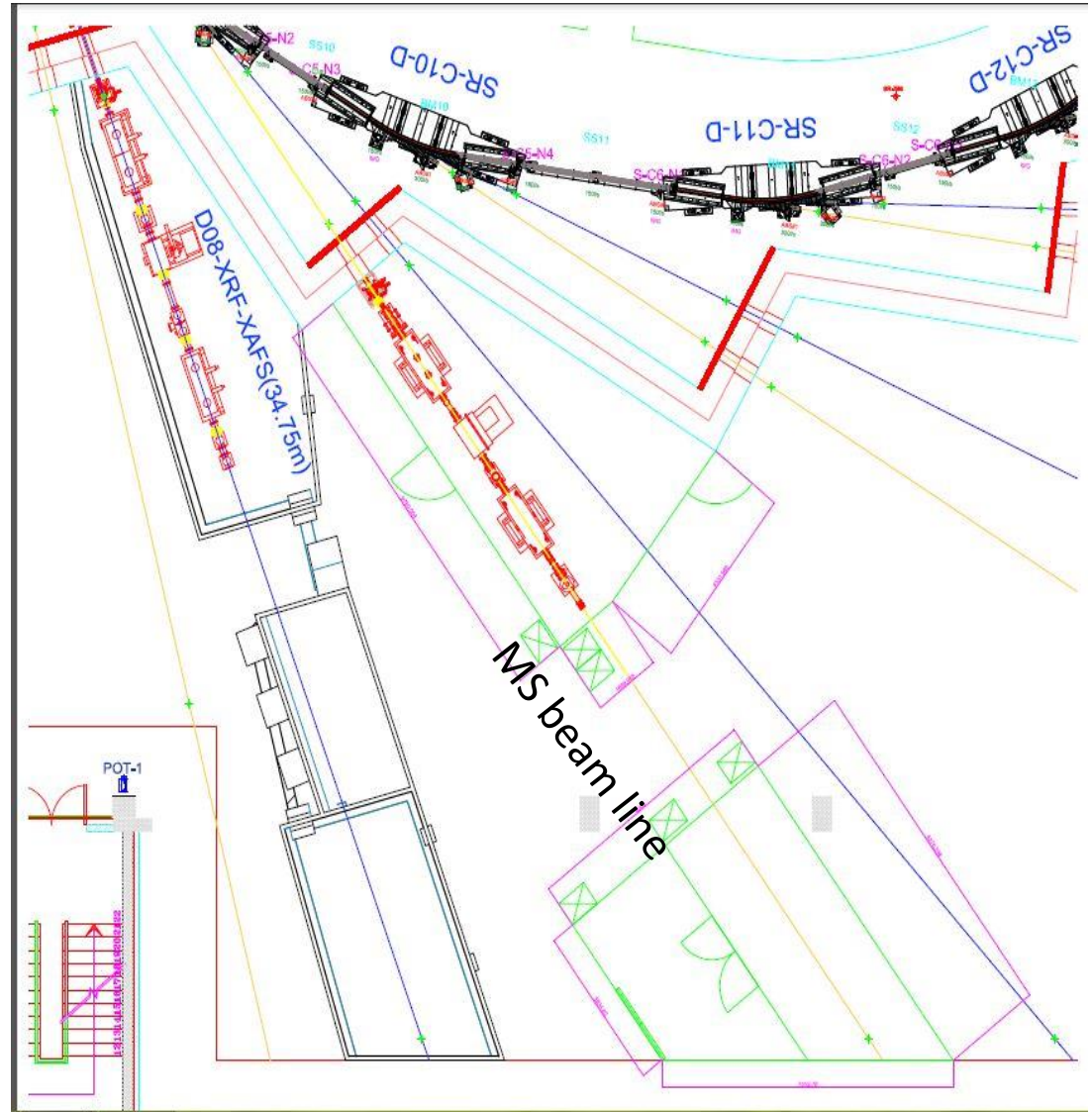
Source

Front end

Optics



# SESAME MS BL layout

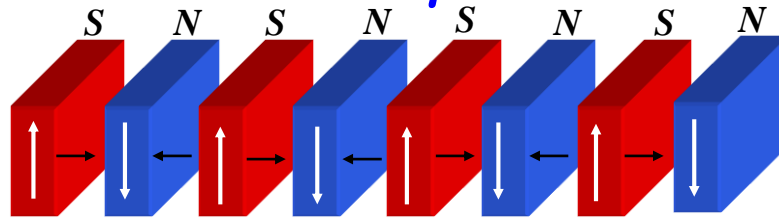


Overall W61 length (m)	2
Wiggler gap (mm)	12
Period length (mm)	60.5
Number of periods	33
Magnetic material	NdFe:B
Pole material	CoFe
Maximum field (T)	1.4
Deviation parameter K	7.8
Critical energy (keV)	5.8
Total power @ 400mA (KW)	6.01

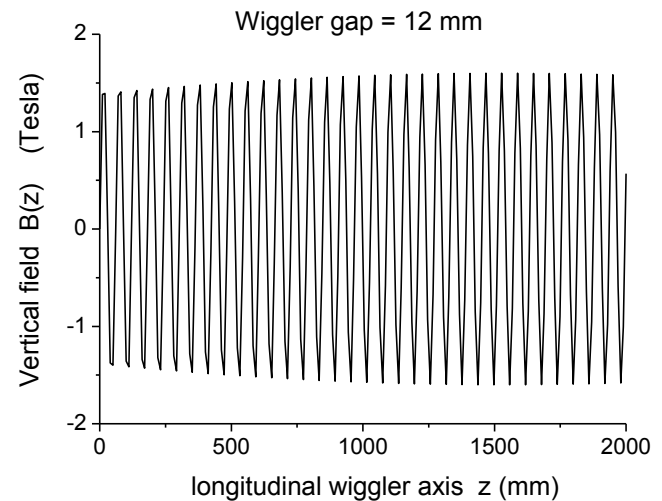
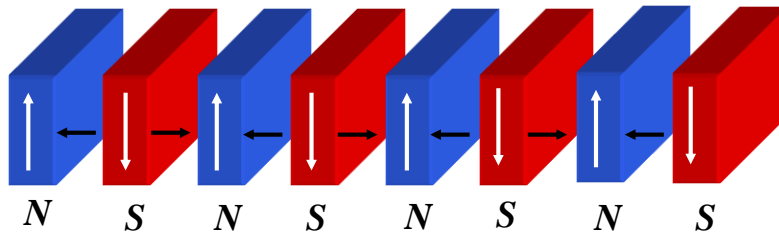
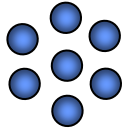
# SESAME MS radiation source W61

The particle follow zigzag path according to Lorentz magnetic force

$$F = q v \times B$$

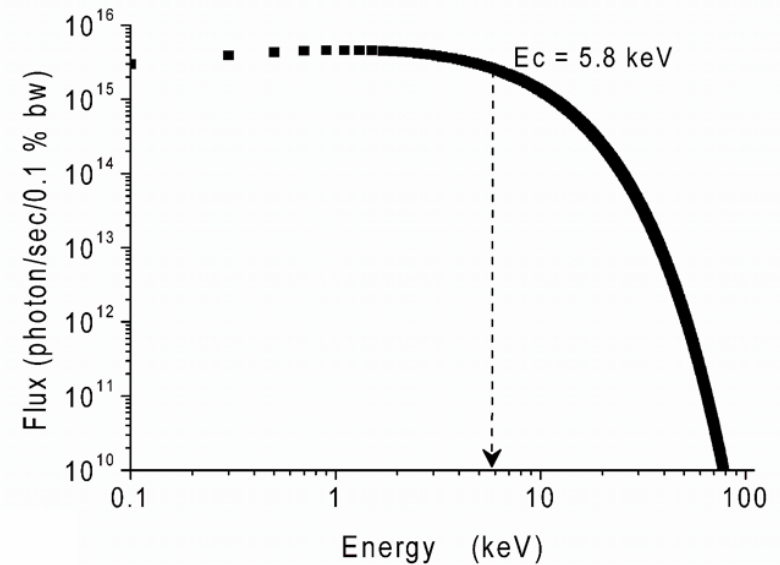
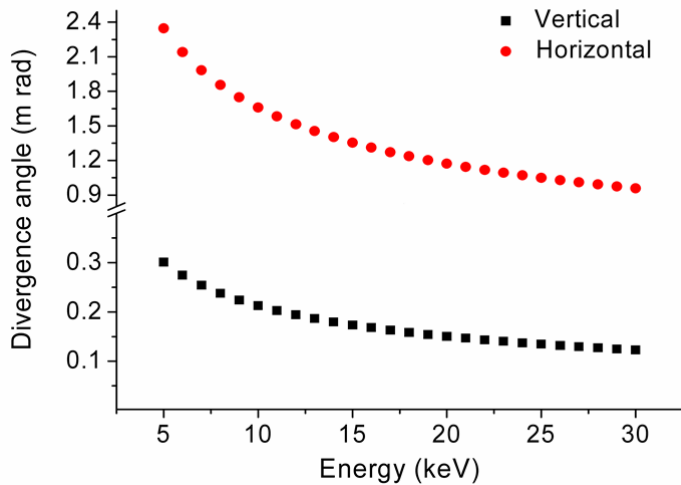
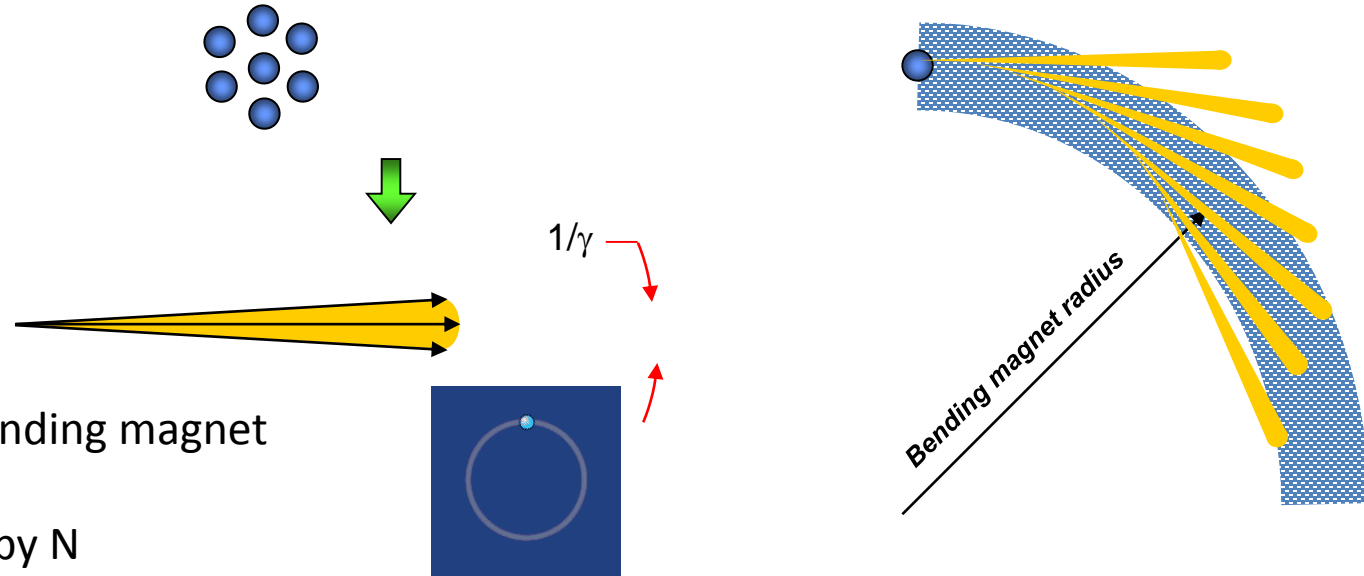


Periodic magnetic structure





# Wiggler Vs Bending magnet



## Front end

## Optics

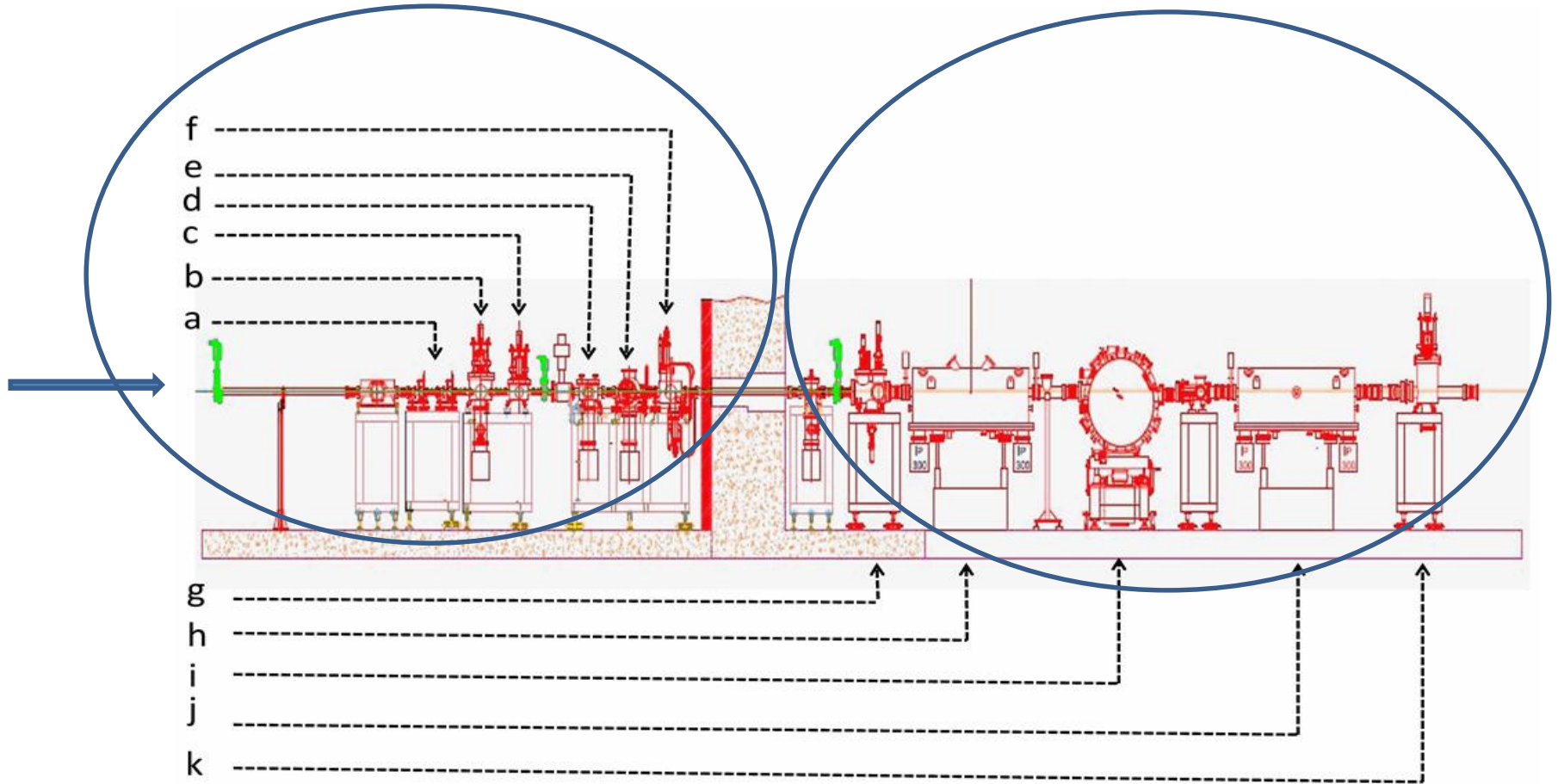
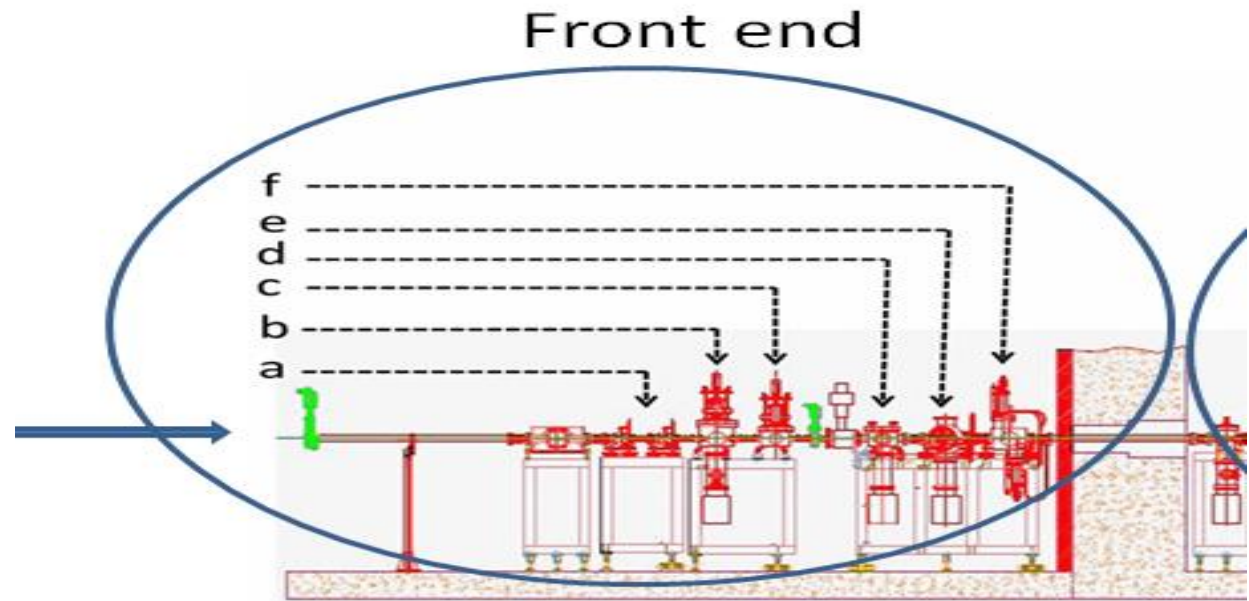


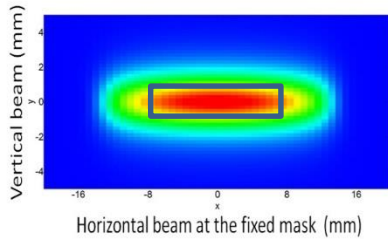
Figure front-end and optics layout starting from left hand side, fixed masks (a), shutter (b), stopper (c), filter (d), vertical slits (e), horizontal slits (f), fast absorber (g), collimating mirror (h), monochromator (i), focusing mirror (j), photon shutter (k).



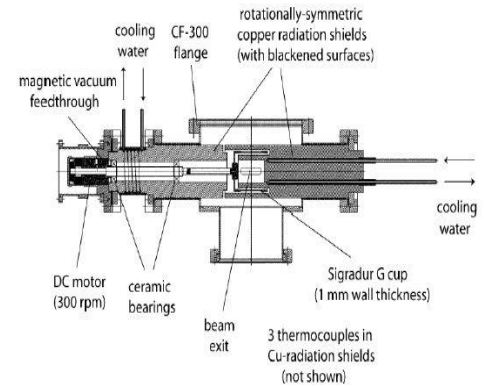
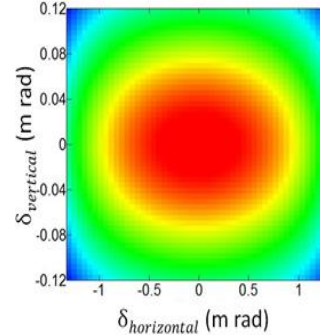
- Defining the angular acceptance
- Blocking X-ray and Bremsstrahlung radiation
- Soft X ray filtration
- Isolation the vacuum of beamline from and storage ring vacuum (Be windows)

# Power and heat load analysis

$$P[\text{kW}] = 1.27 E_e^2 [\text{GeV}^2] \frac{B_{\text{eff}}^2 [\text{T}^2]}{2} L_w [\text{m}] I_e$$

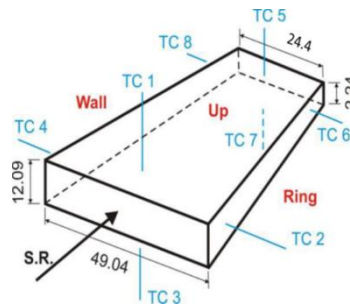


$P(\text{abs}) = 2.46 \text{ K Watt}$



6.01 K Watt

Source

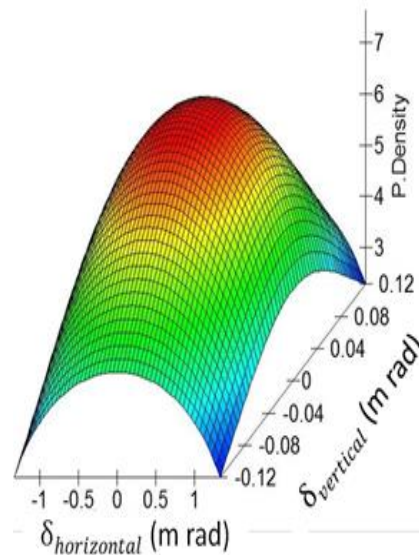
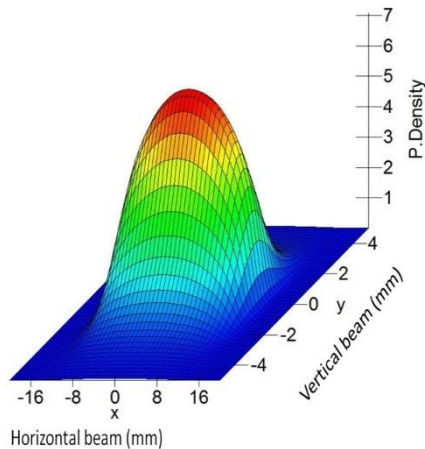


3.55 K Watt



2 mm in total  
Glassy graphite  
1.42 g/cm<sup>3</sup>

Diaphragm



Current (m A)	Total Absorbed power (k Watt)
200	1.3
300	1.9
400	2.6



# Temperature load on the filter

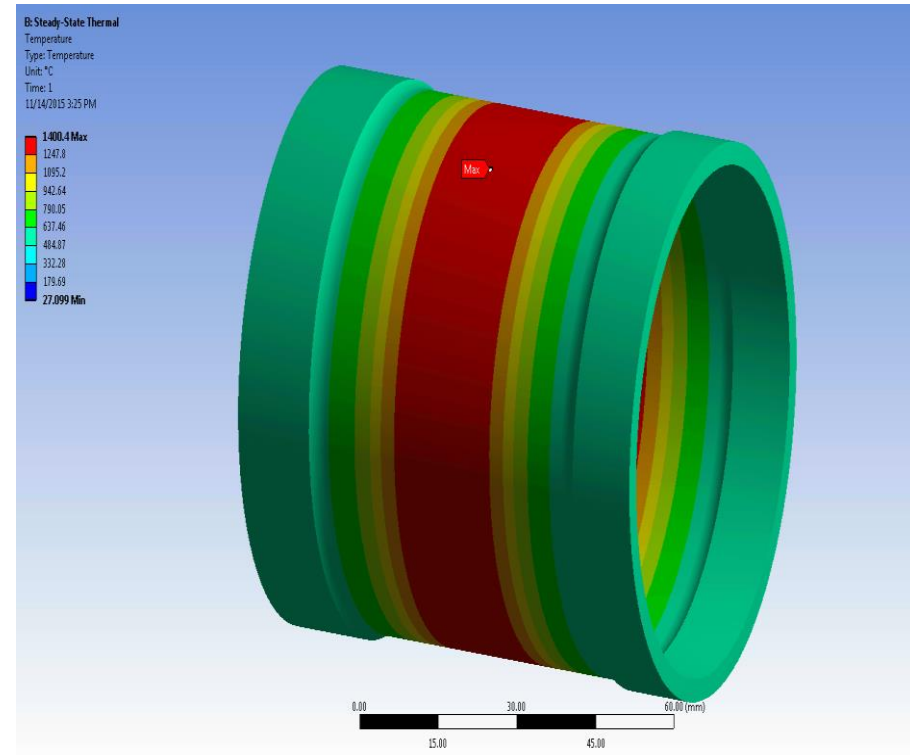
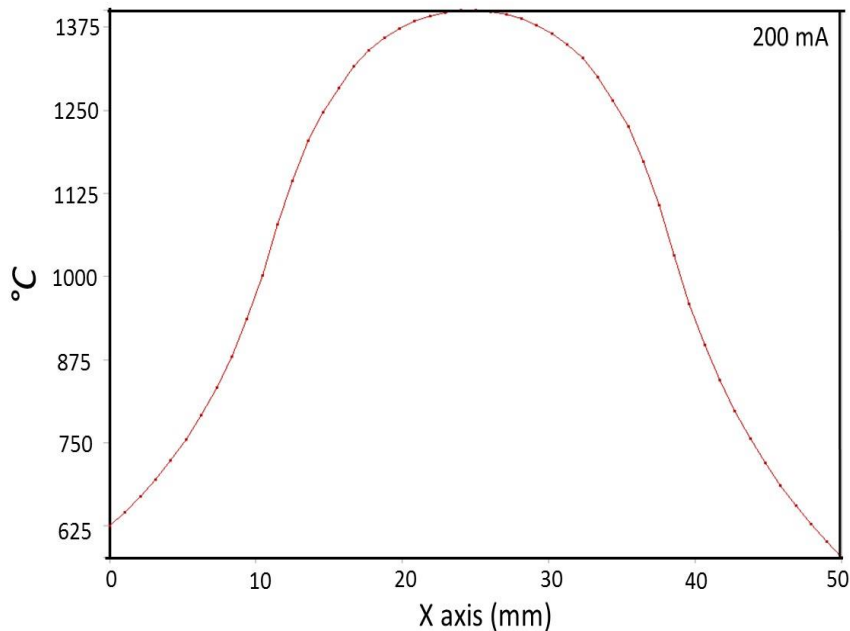
## Case I

$I$  (electrons) = 200 mA

Total absorbed power 1288W

Temperature (1400 – 625 °C)

Max Copper temp. = 100 °C



# Temperature load on the filter

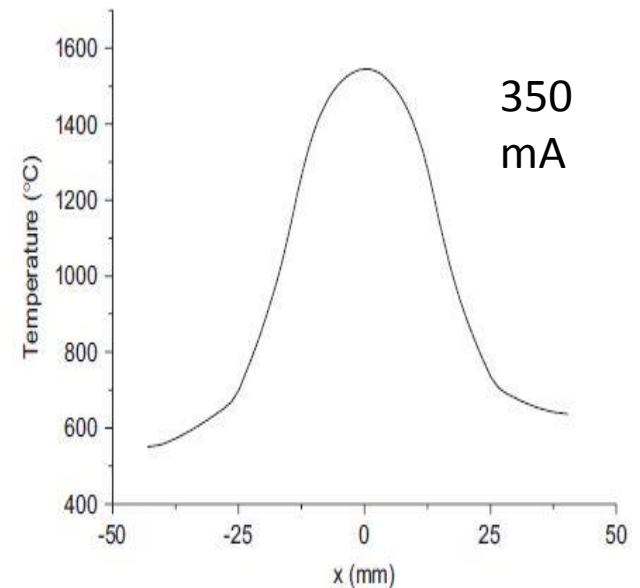
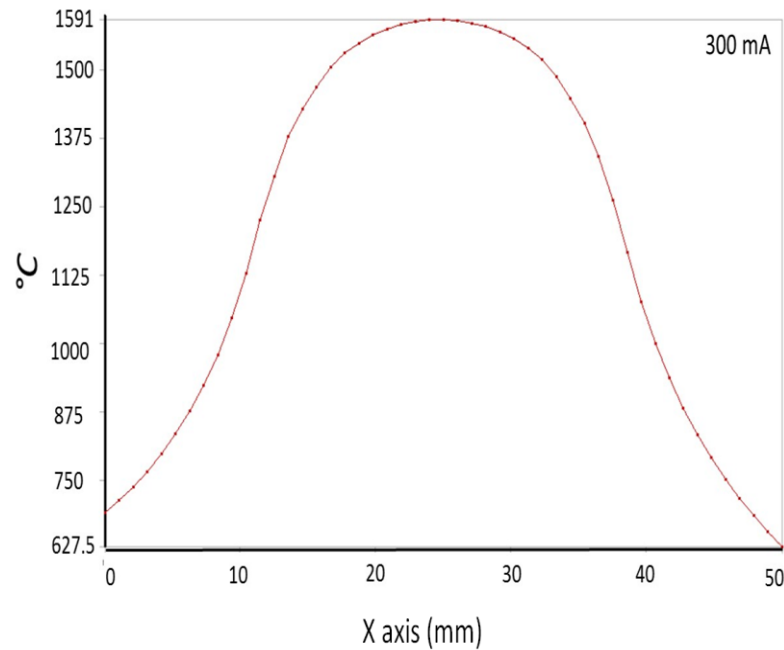
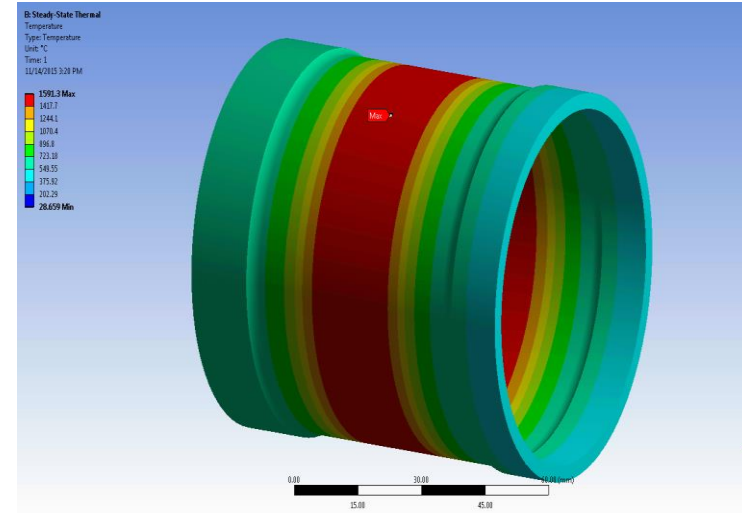
## Case II

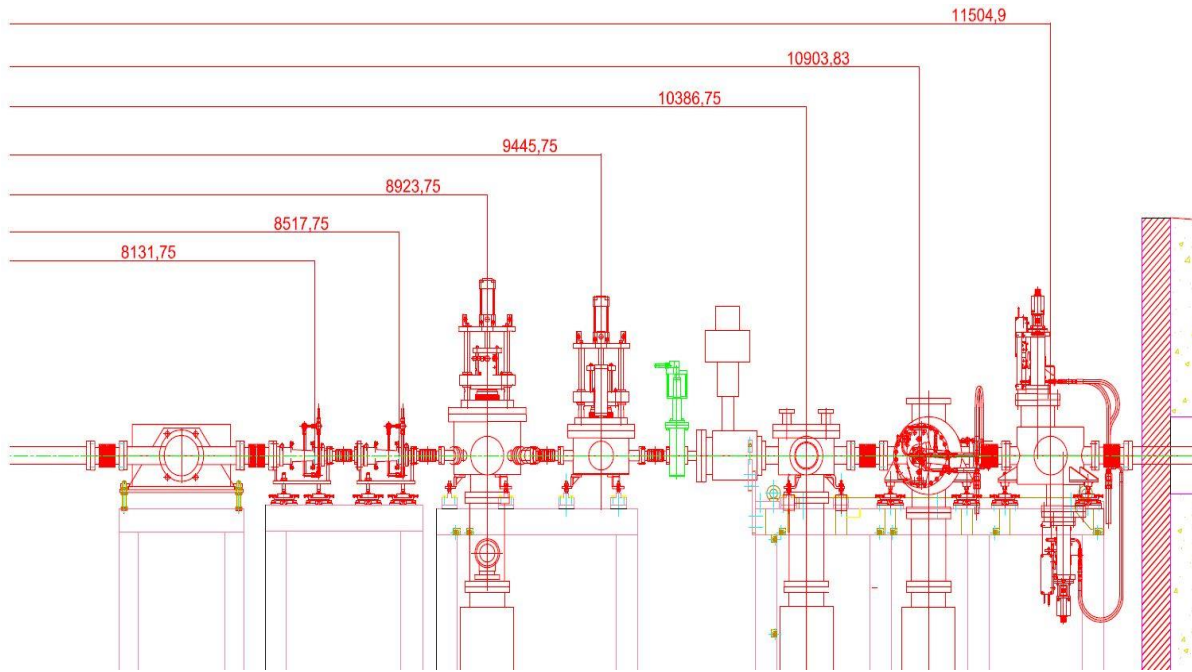
$I$  (electrons) = 300 mA

Total absorbed power 1932W

Temperature (1600 – 730 °C)

Max Copper temp. = 135 °C





Case III

I (electrons) = 400 mA

Total absorbed power  
2.6 KW

1.5 (H) x 0.23 (V) m rad<sup>2</sup> @ 400 mA

Decreasing the horizontal acceptance  
down to 1.5 m rad

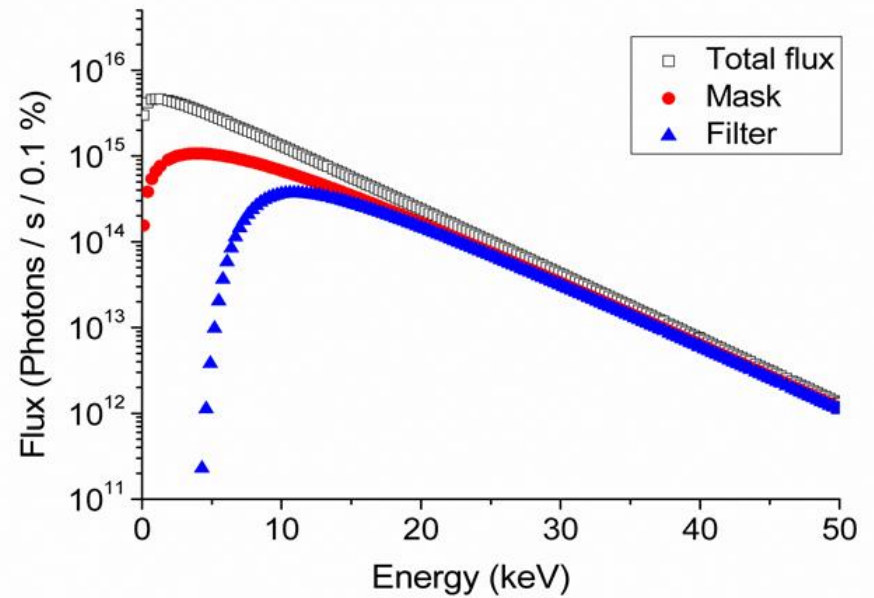
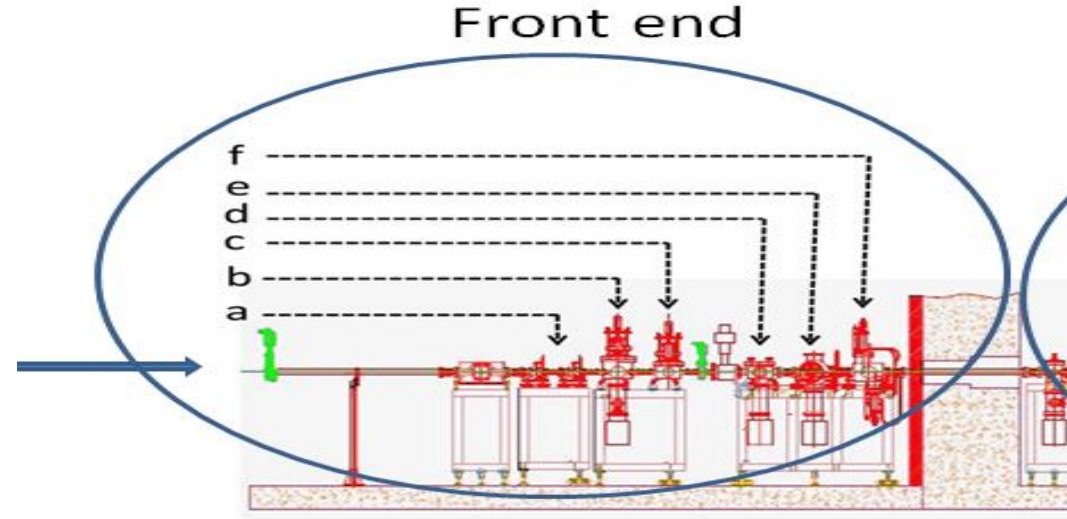
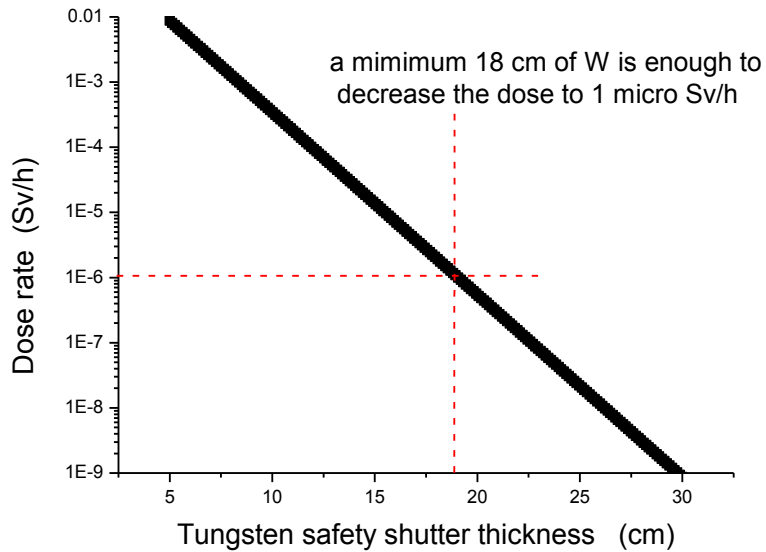
	Power in (kW)	Power out (kW)	Power absorbed (kW)
Fixed mask 1	6	4.13	1.87
Fixed mask 2	4.13	2.15	1.98
Rotating filter	2.15	0.614	1.54

Intermediate situation

1400 °C < T max < 1600 °C

625 °C < T min < 730 °C  
100 °C < T (Cu) < 135 °C

# Shutter and stopper (safety)





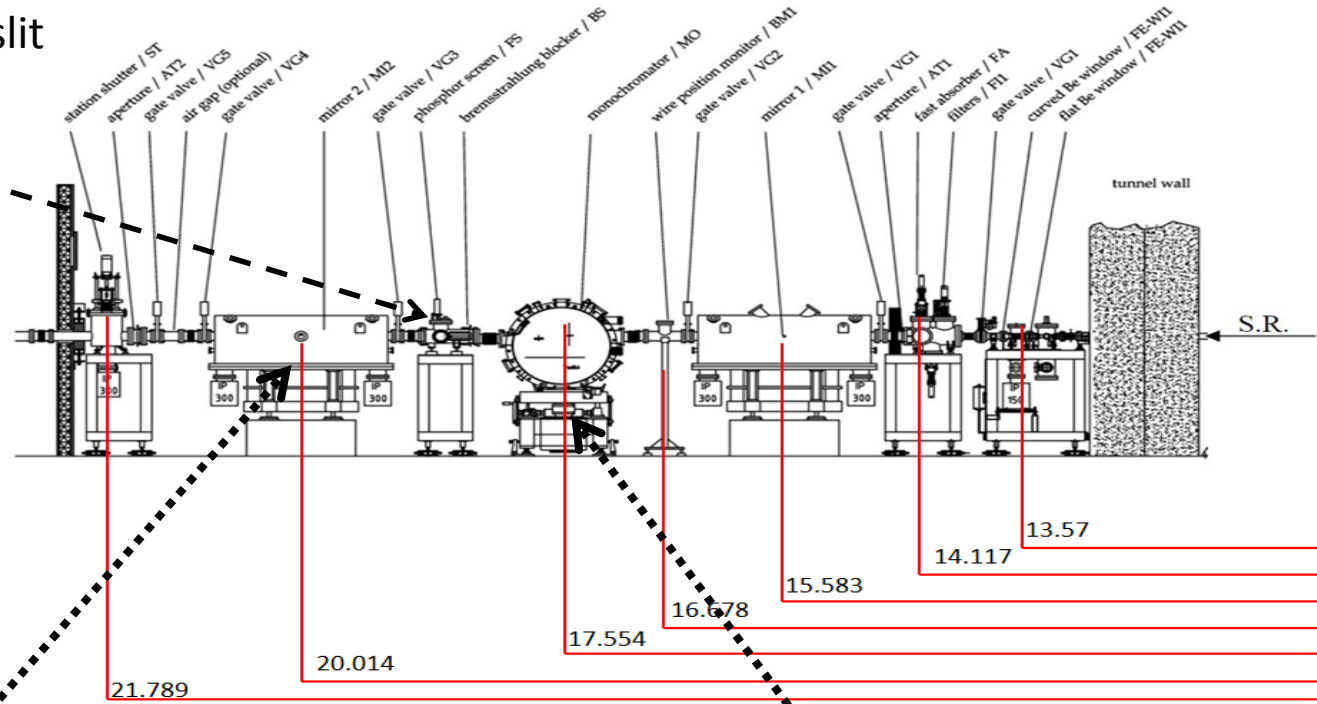
# Optics layout

(no optics is the best optics)

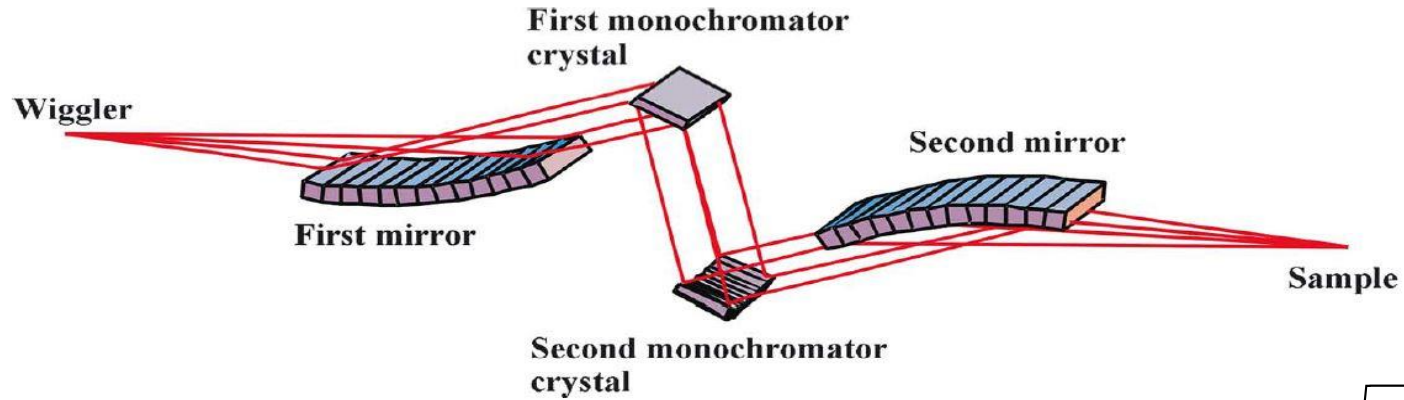


Pink slit

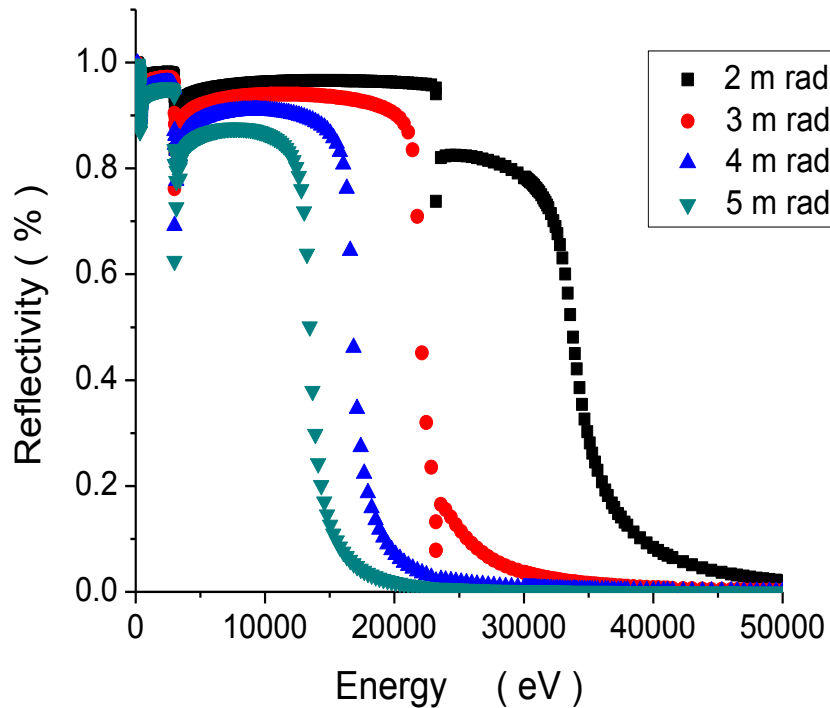
Mono slit



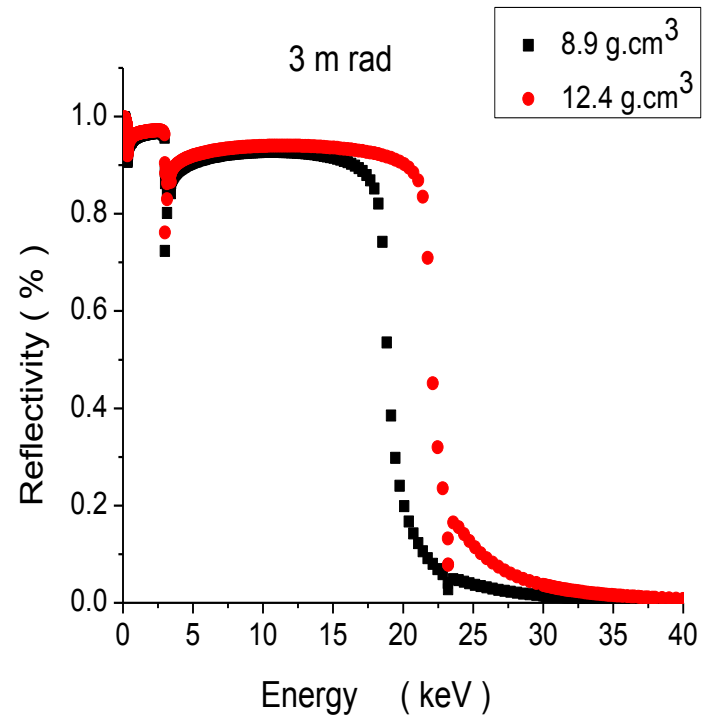
# Collimating Mirror (Rhodium)



M1 and Energy resolution



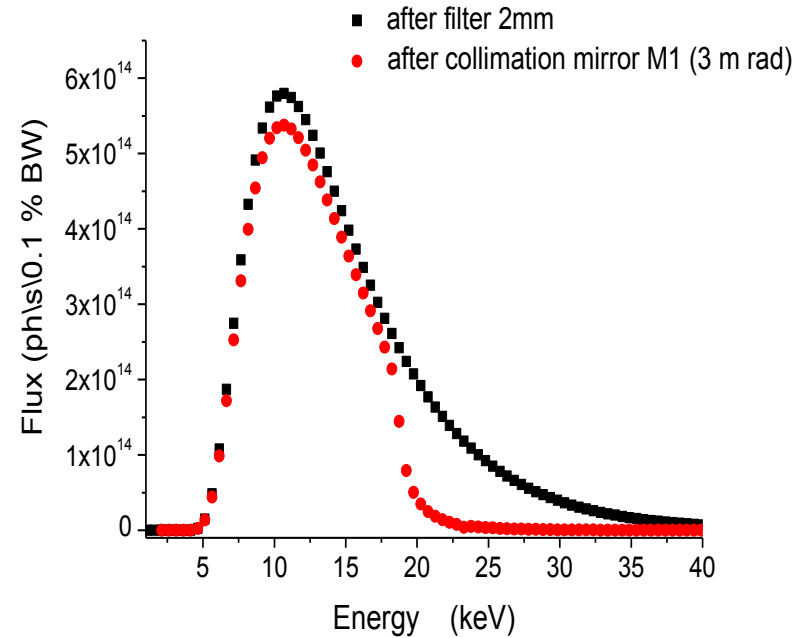
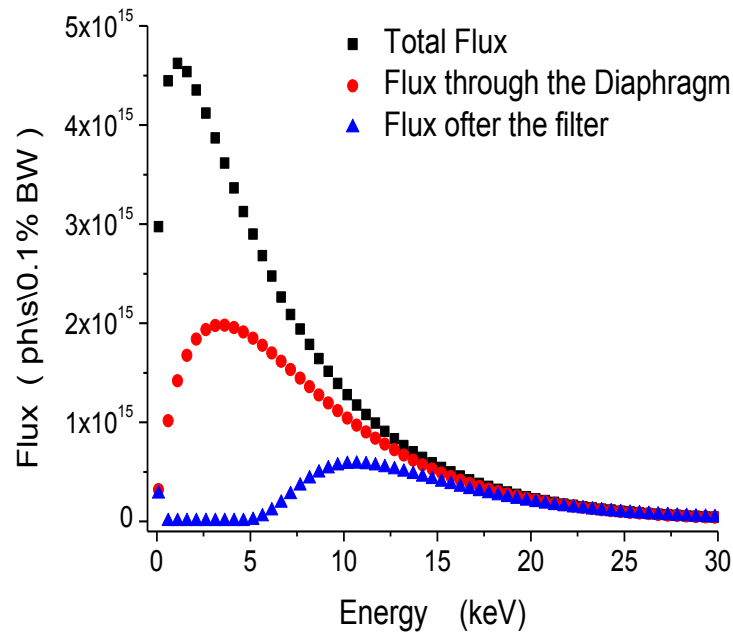
$$\theta_c (\text{m rad}) = \frac{19.83 \sqrt{\rho_s \left(\frac{\text{g}}{\text{cm}^3}\right)}}{E_c (\text{keV})}$$



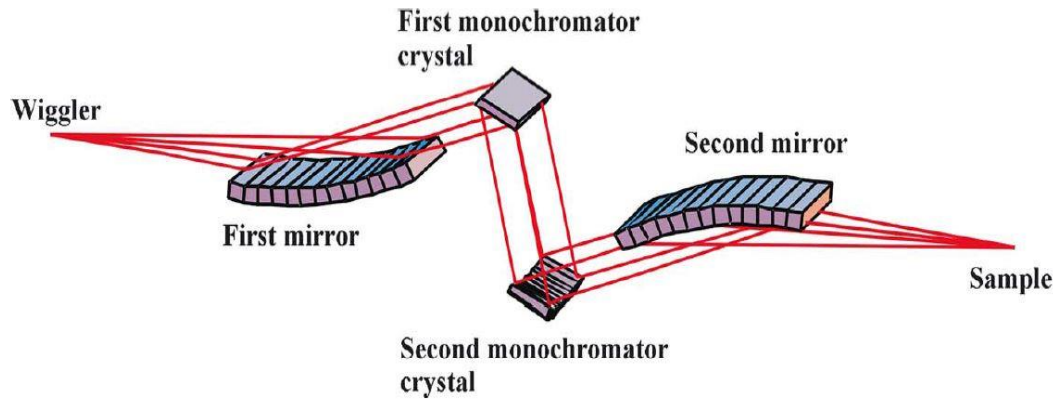
# Collimating Mirror (Rhodium)

Mirror absorbs some power

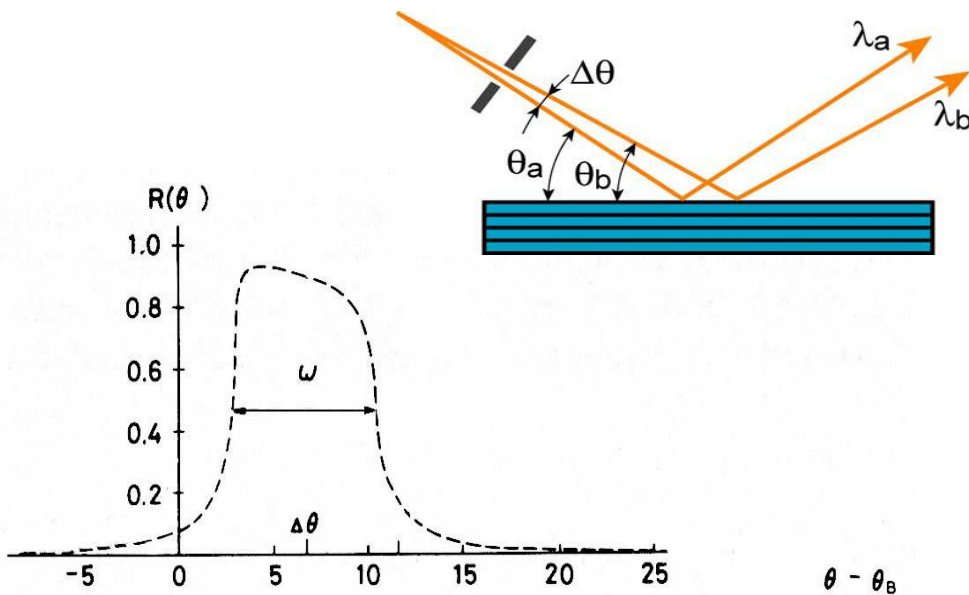
Mirror collimates the incoming radiation (energy resolution..)



# Monochromator and horizontal focusing



$$\frac{\Delta E}{E} = \frac{\Delta \lambda}{\lambda} = \sqrt{\Delta \theta^2 + w^2} \cot(\theta)$$



hkl	Bragg angle (degree)	$\omega$ (arc sec)	$\omega$ ( $\mu$ rad)
111	11.403	5.476	26.55
220	18.836	3.984	19.32
311	22.246	2.273	11.02
400	27.167	2.495	12.10
422	34.001	1.886	9.142
333	36.379	1.228	5.952
440	40.22	1.543	7.479



# Outlines

**Introduction**

**MS Layout**

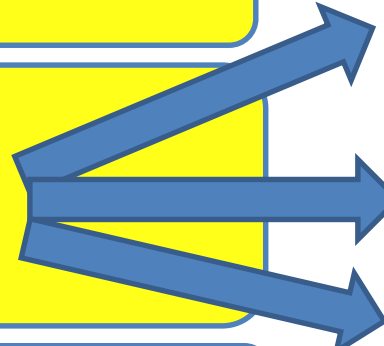
**Ray Tracing**

**Experimental**

**Source**

**Front end**

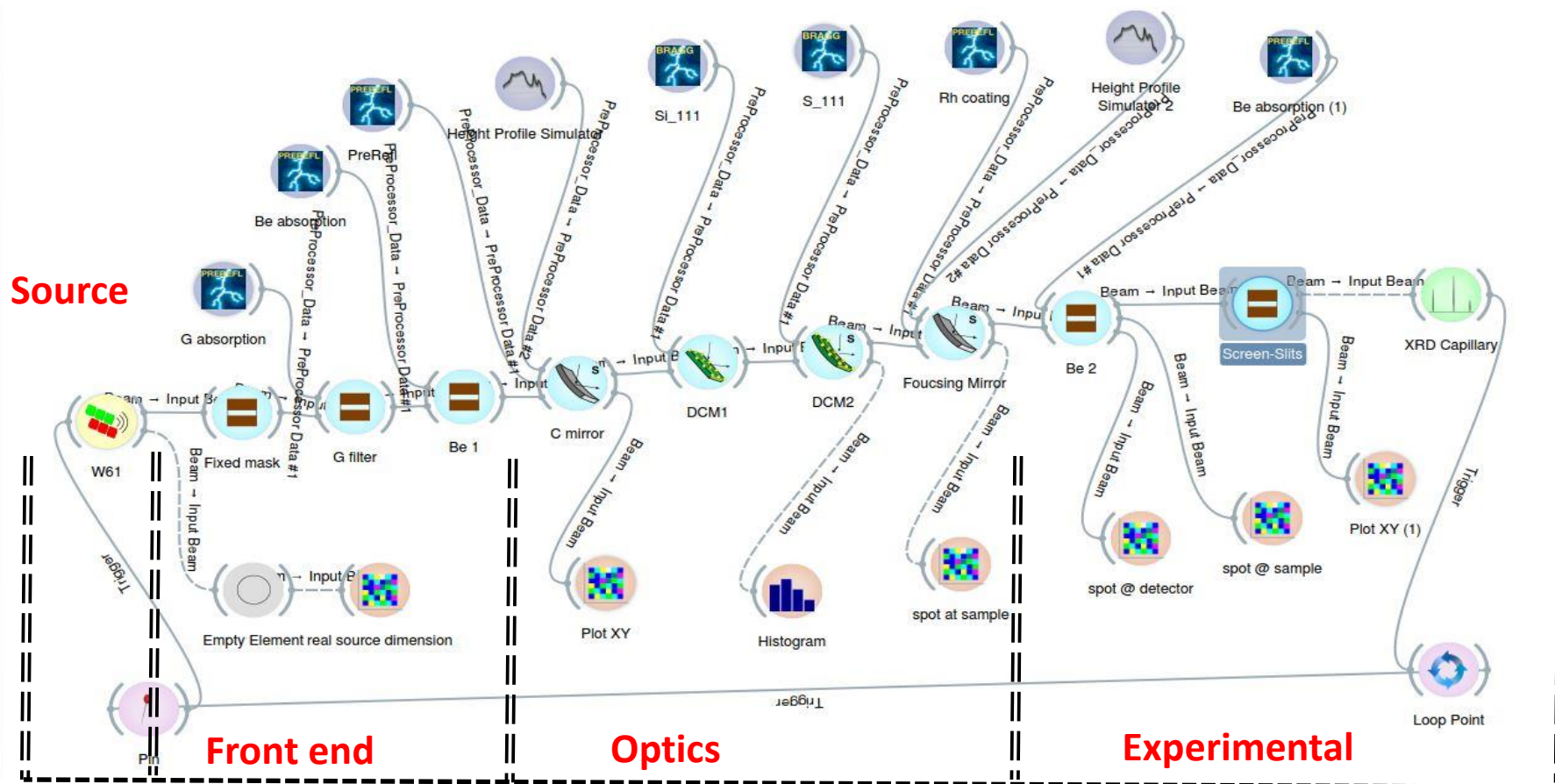
**Optics**



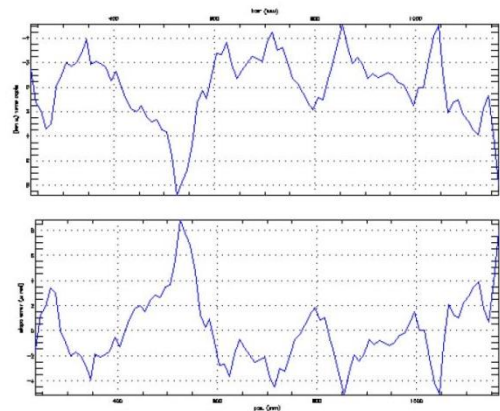
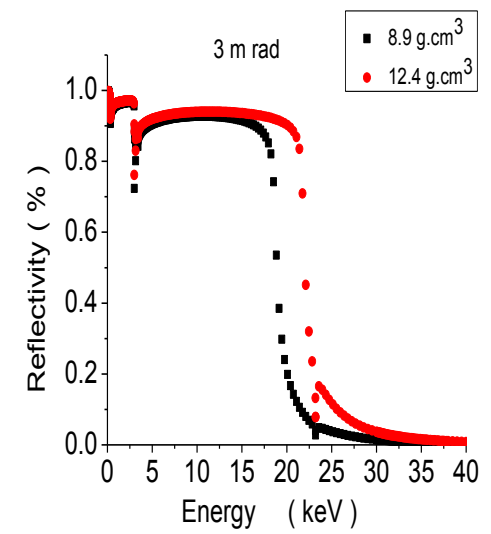
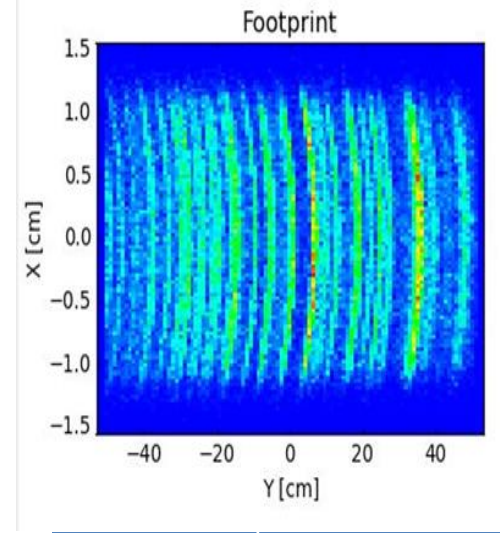
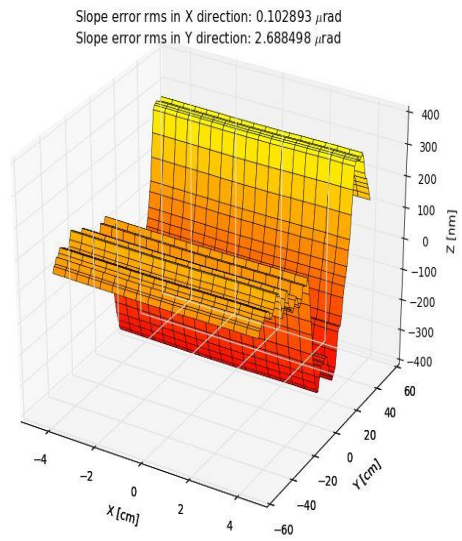
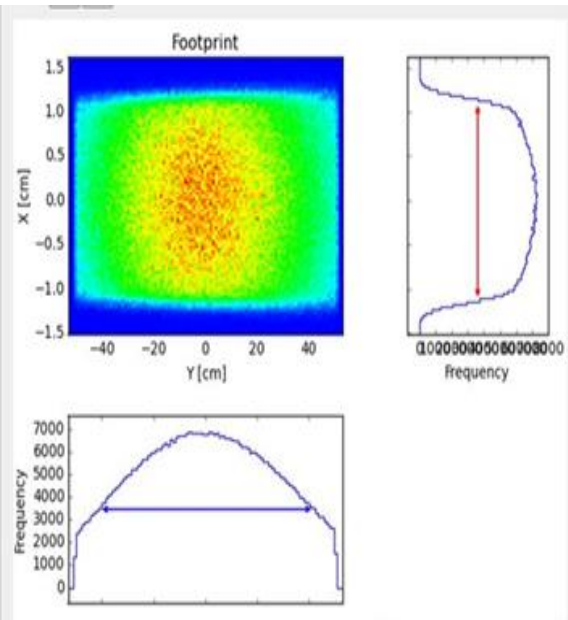
# Ray Tracing



- Tuning optics to optimize Flux at Sample (photons/s) and the angular resolution



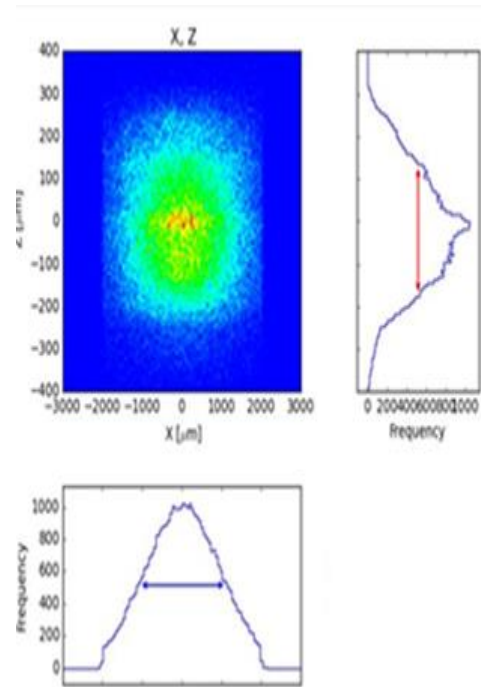
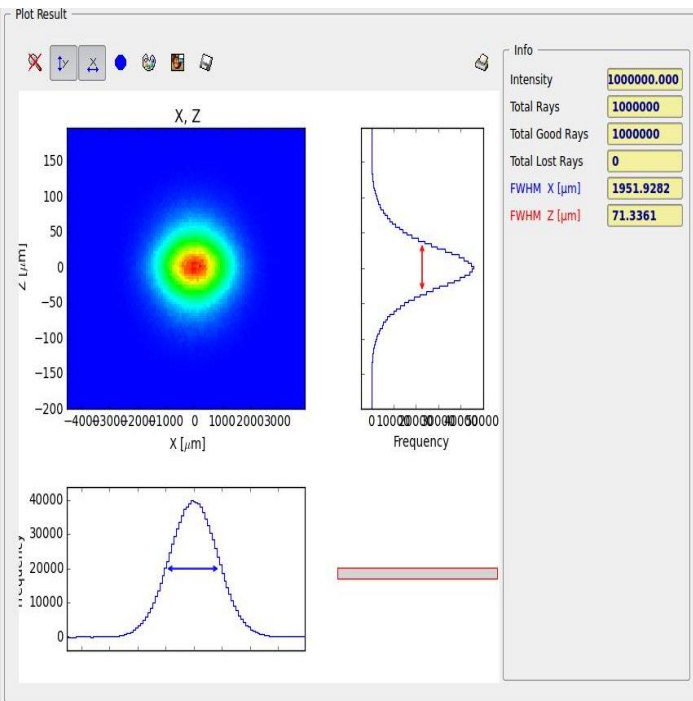
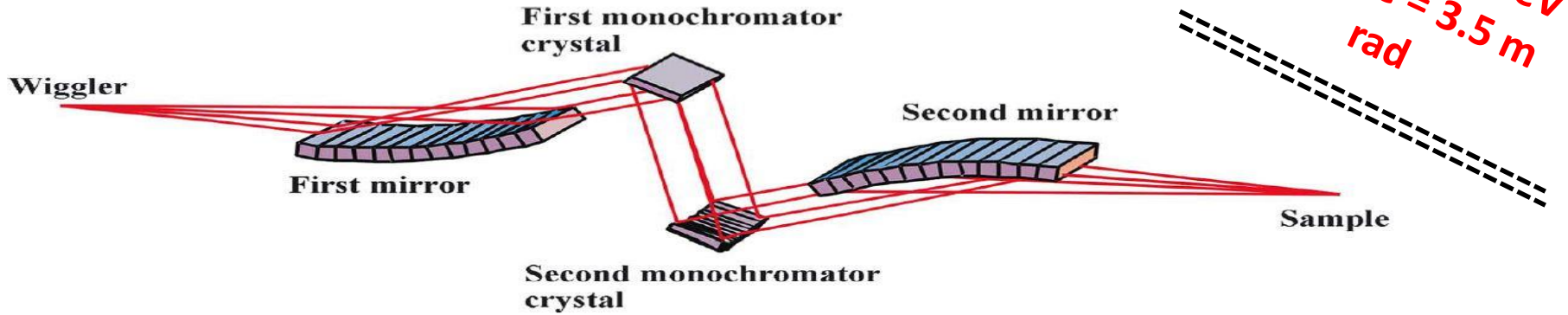
Sanchez del Rio, M. et al. (2014). "A proposal for an open source graphical environment for simulating x-ray optics". *Proc. SPIE 9209, Advances in Computational Methods for X-Ray Optics III*, 92090X; doi:10.1117/12.2061834



	Slope error $\mu$ rad (rms)
M1	3.561
M2	2.626

Rebuffi, L. & Sanchez del Rio, M. (2016). "ShadowOui: A new visual environment for X-ray optics and synchrotron beamline simulations", J. Synch. Radiat., submitted.

# Optics optimization

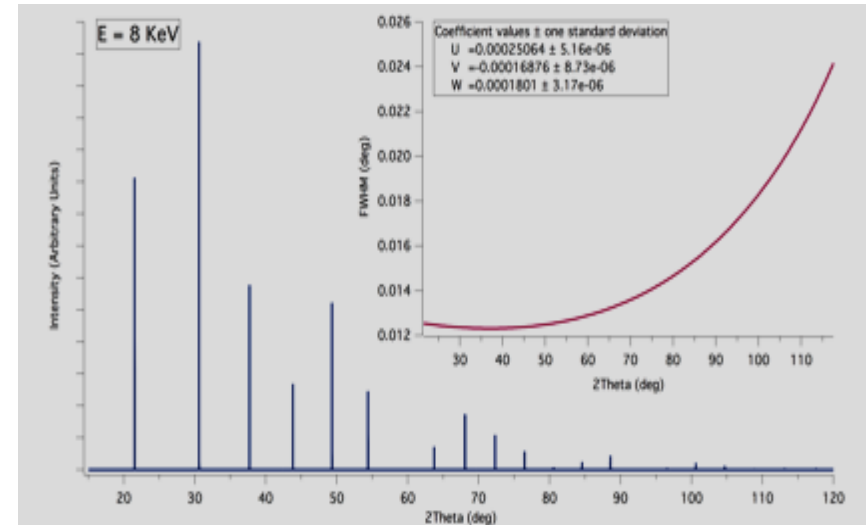
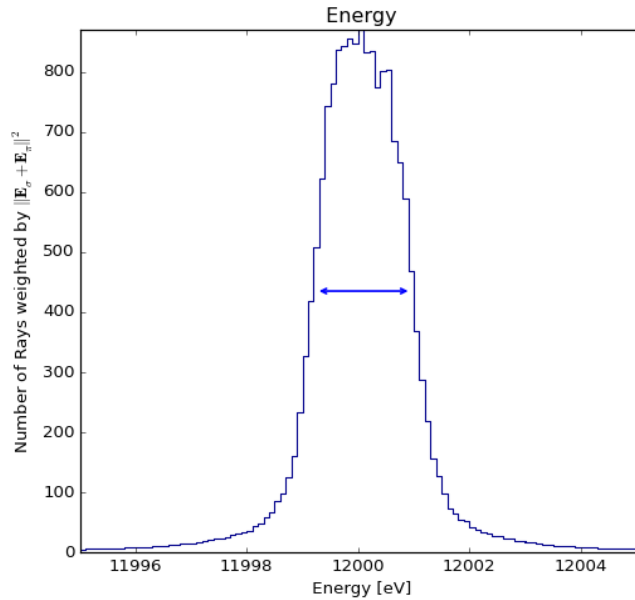
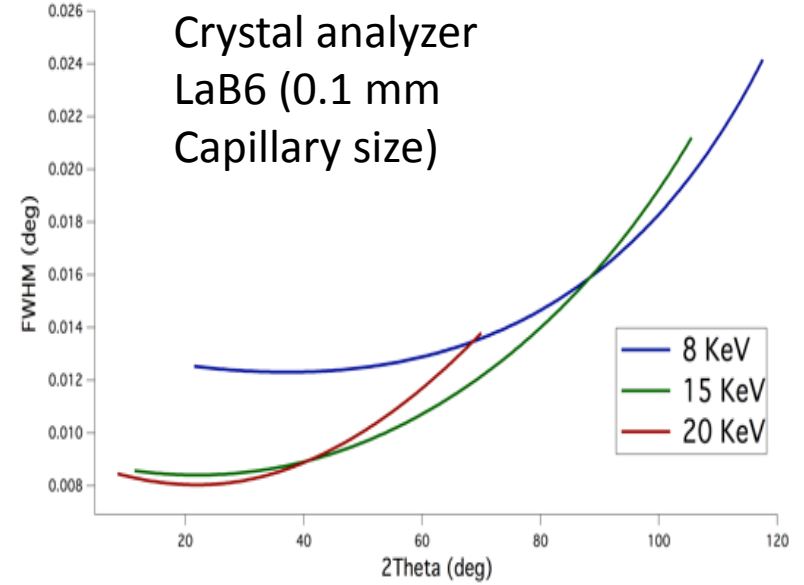
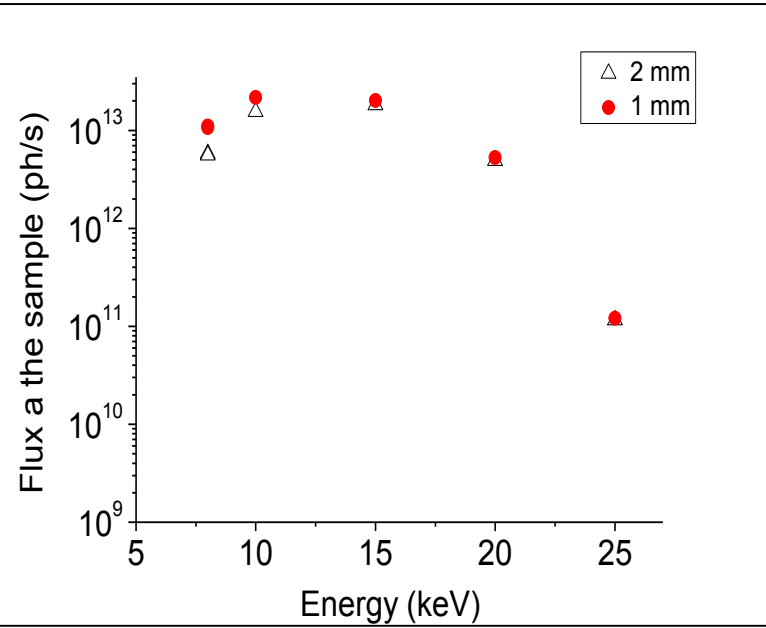


## Effective beam size

Vertical = 0.8 mm  
(FWHM = 0.3 mm)

Horizontal = 4 mm  
(FWHM = 2 mm)

# Flux and instrumental Profile





# Outlines

**Introduction**

**MS Layout**

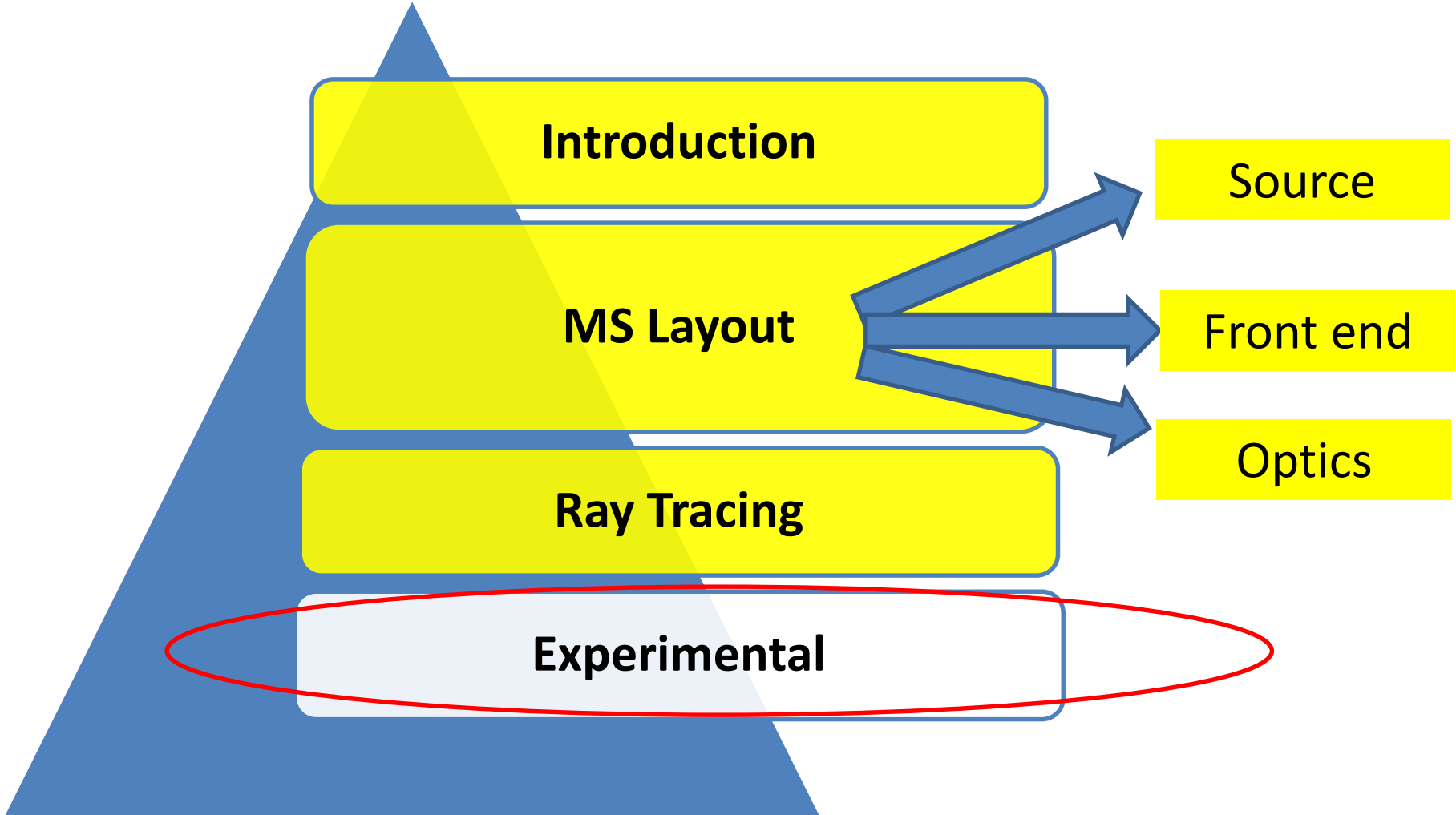
**Ray Tracing**

**Experimental**

**Source**

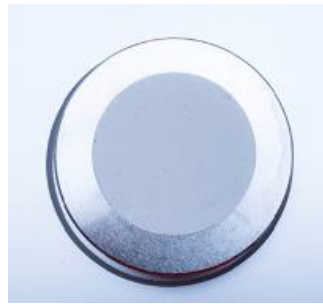
**Front end**

**Optics**

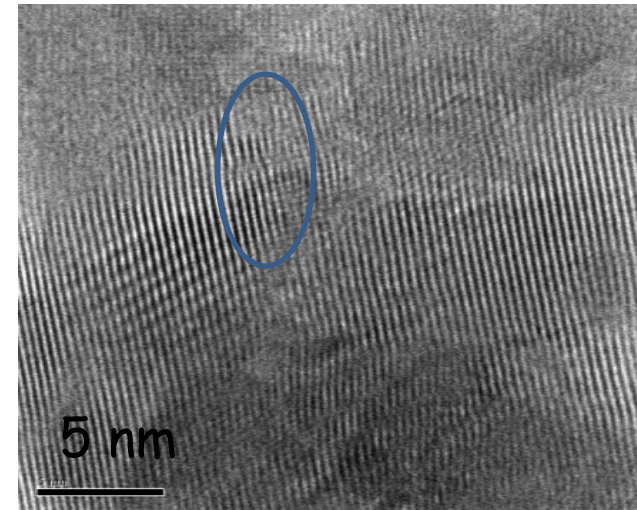


# Experimental main aspects?

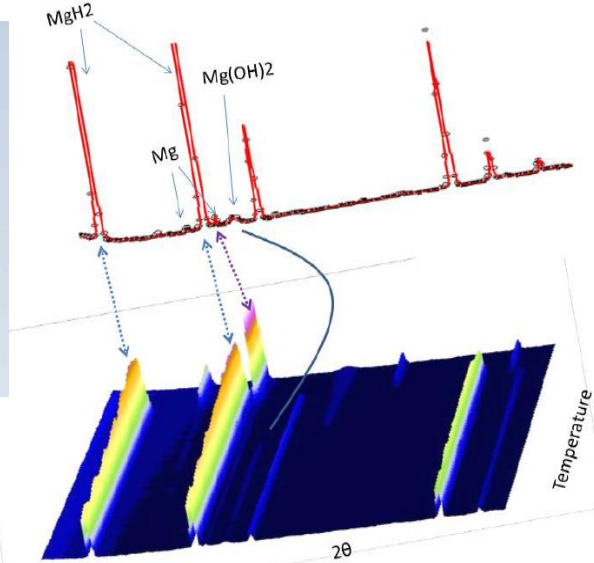
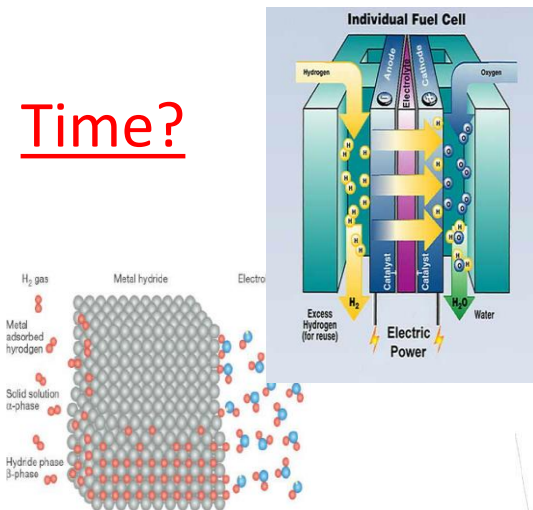
## ➤ Samples' forms



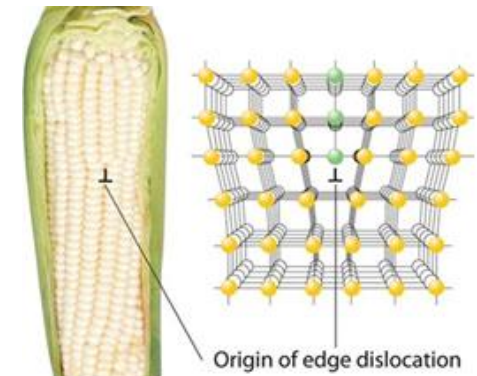
## ➤ Instrumental resolution?



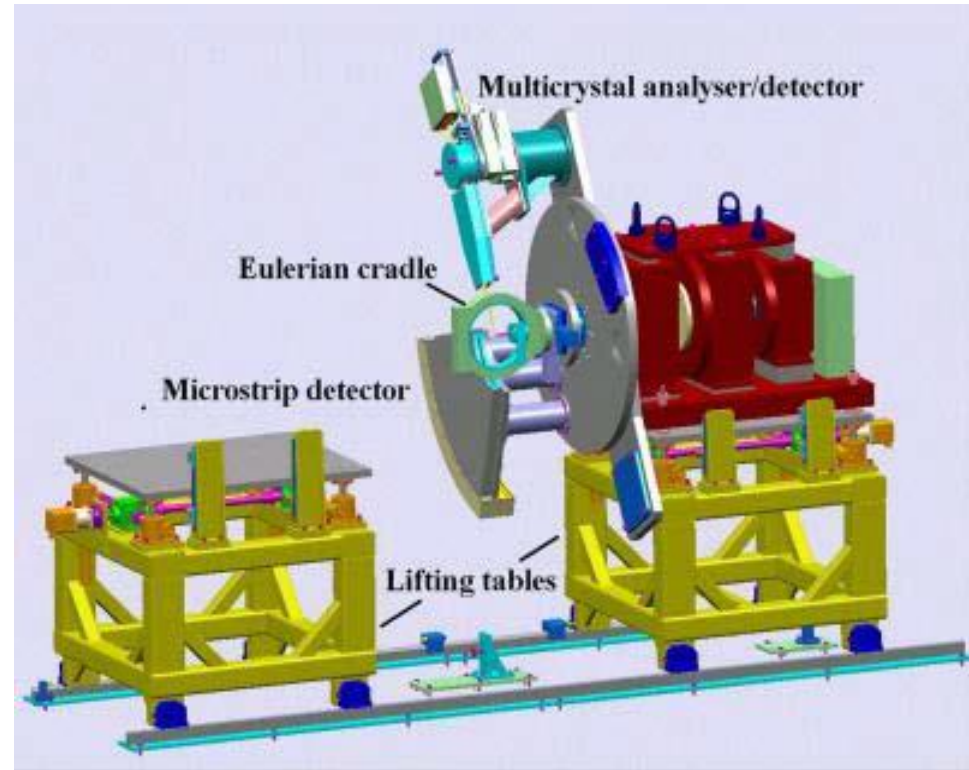
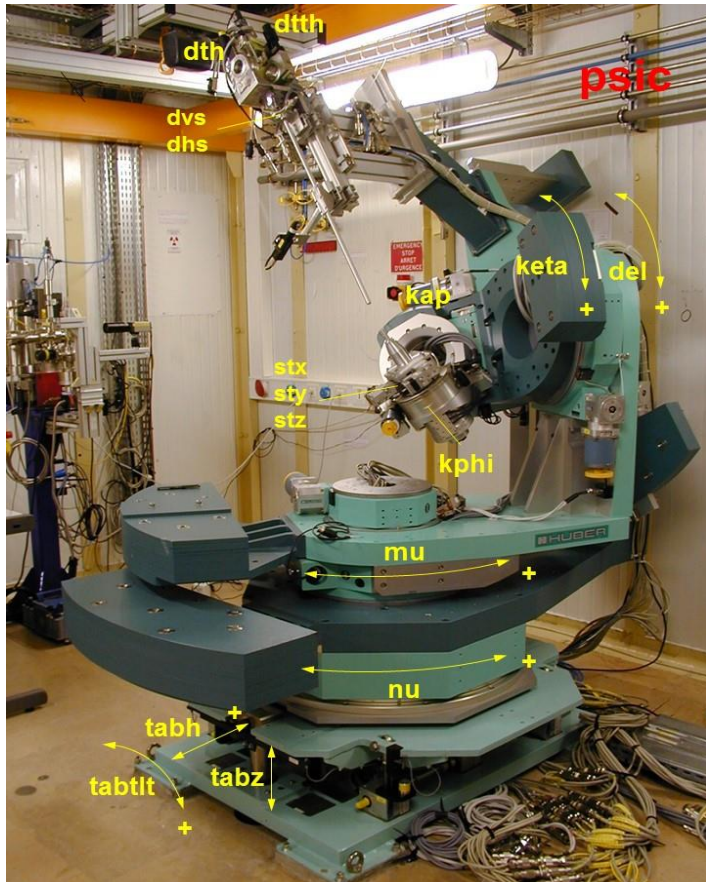
## ➤ Time?



## ➤ Samples' conditions

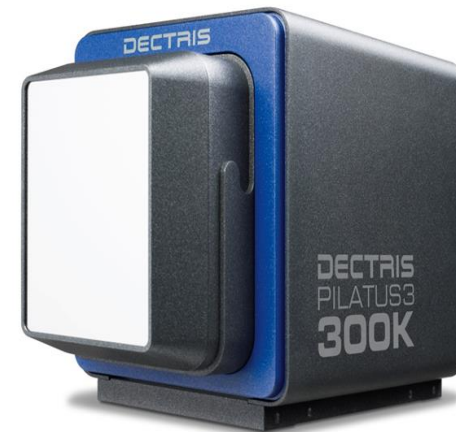
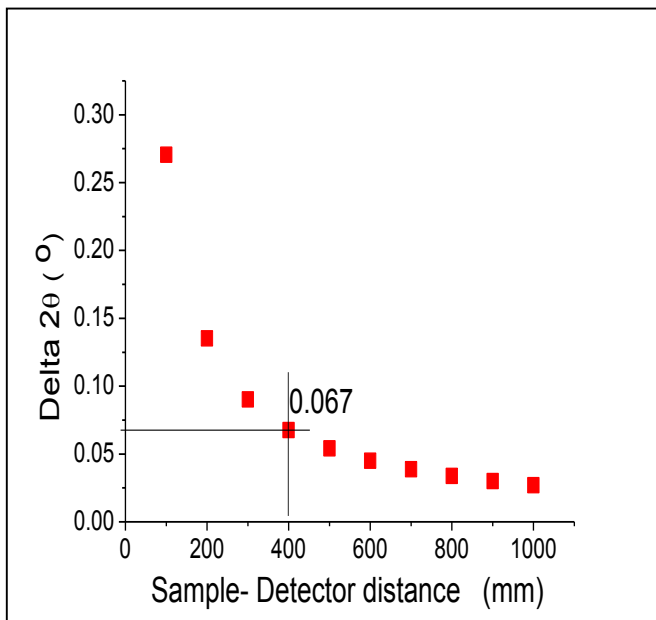


# Diffractometer



# Detector I: DECTRIS PILATUS 300K

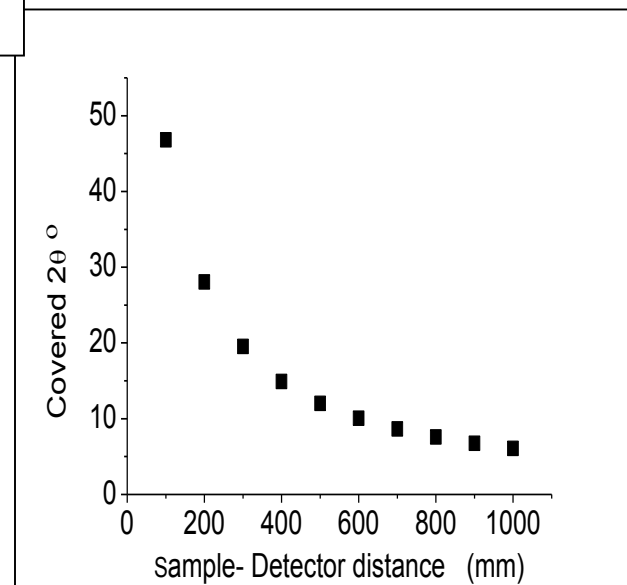
Area	83.8 × 106.5 mm <sup>2</sup>		
Pixel size	172 × 172 μm <sup>2</sup>		
Format	487 × 619 = 301,453 pixels		
Dynamic range	20 bits (1:1,048,576)		
Readout time	7 ms		
Framing rate	500 Hz		
Point-spread function	< 1 pixel		
Silicon sensor thickness	320 μm	450 μm	
Quantum efficiency*	91 %	91 %	5.4 keV (Cr)
	96 %	97 %	8.0 keV (Cu)
	37 %	47 %	17.5 keV (Mo)
	20 %	27 %	22.2 keV (Ag)
Cooling	Closed circuit water-cooling unit for temperature stabilization (23 °C)		
Power consumption	30 W		
Dimensions (WHD)	160 × 194 × 262 mm <sup>3</sup>		
Weight (Detector Head)	7.5 kg		



## Applications:

Time is main matter

- In Situ XRD
- Single crystal diffraction



# Outlines

**Introduction**

Source

**MS Layout**

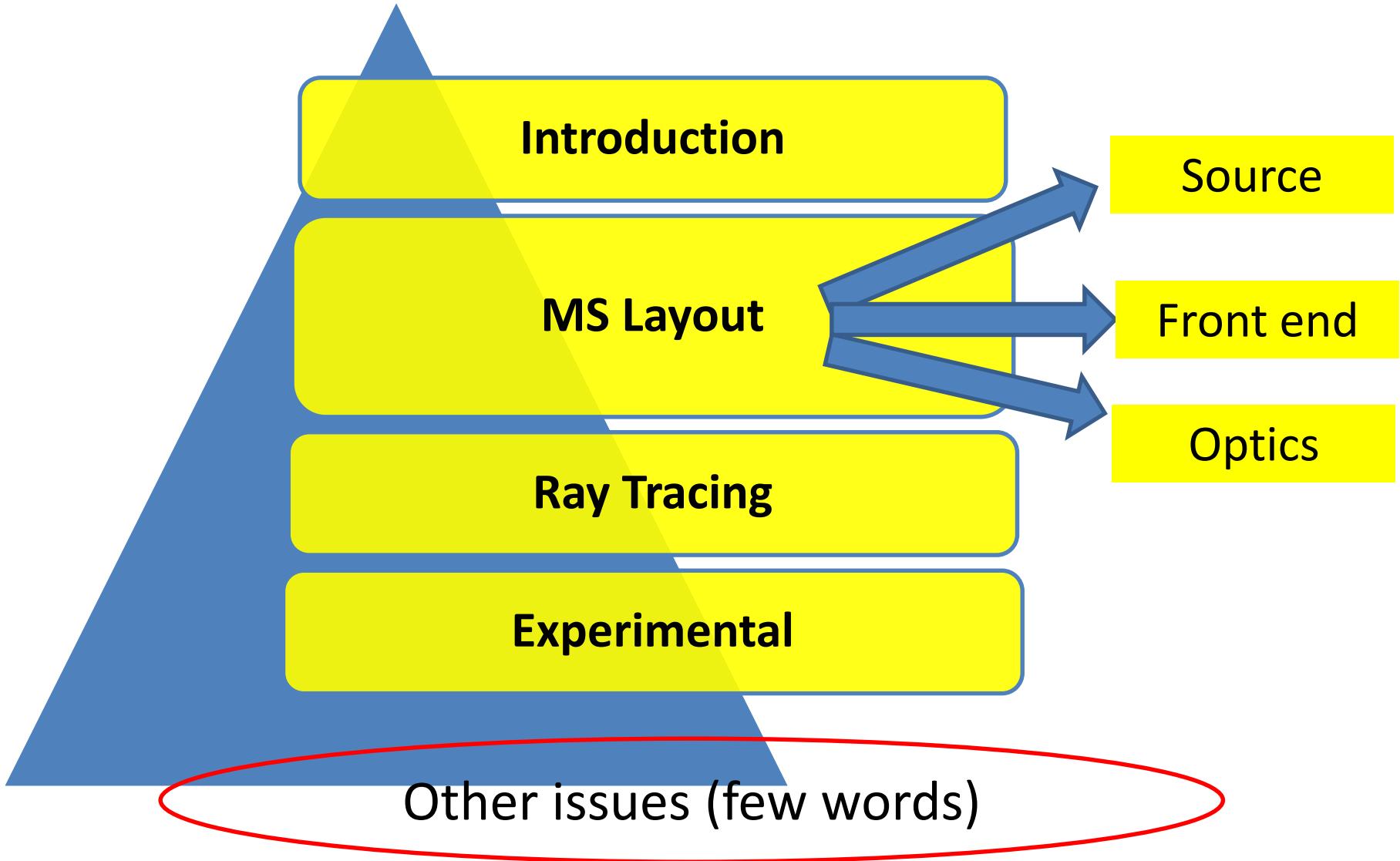
Front end

**Ray Tracing**

Optics

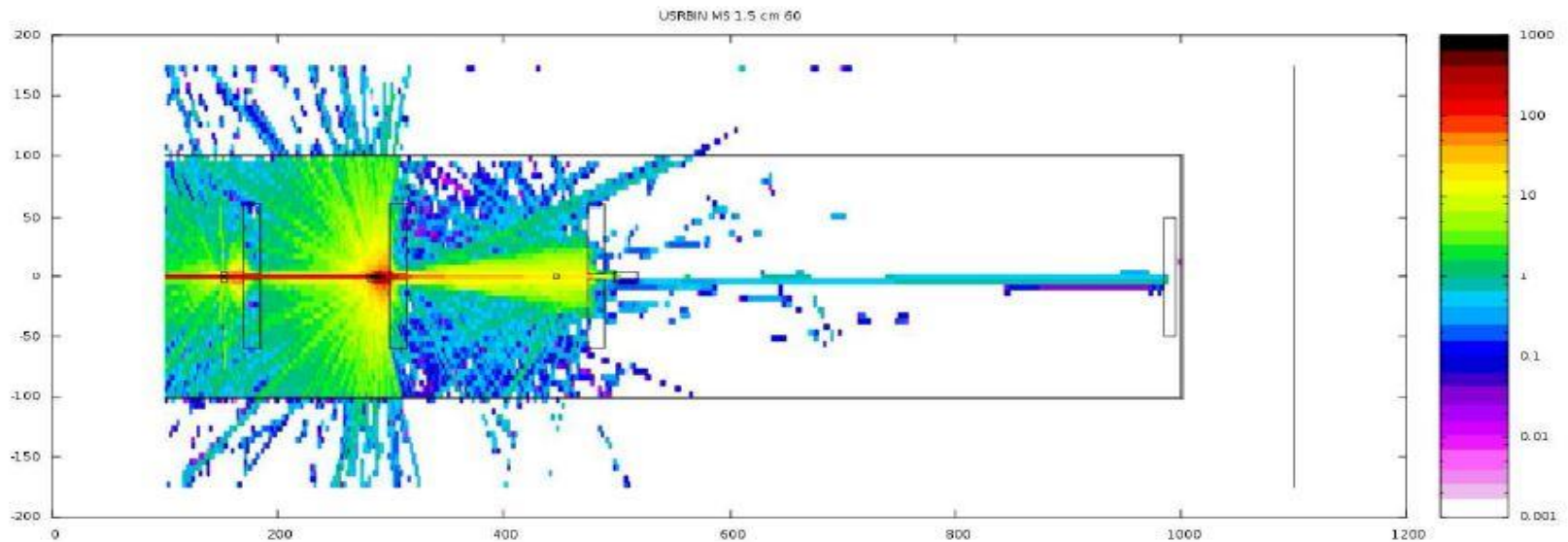
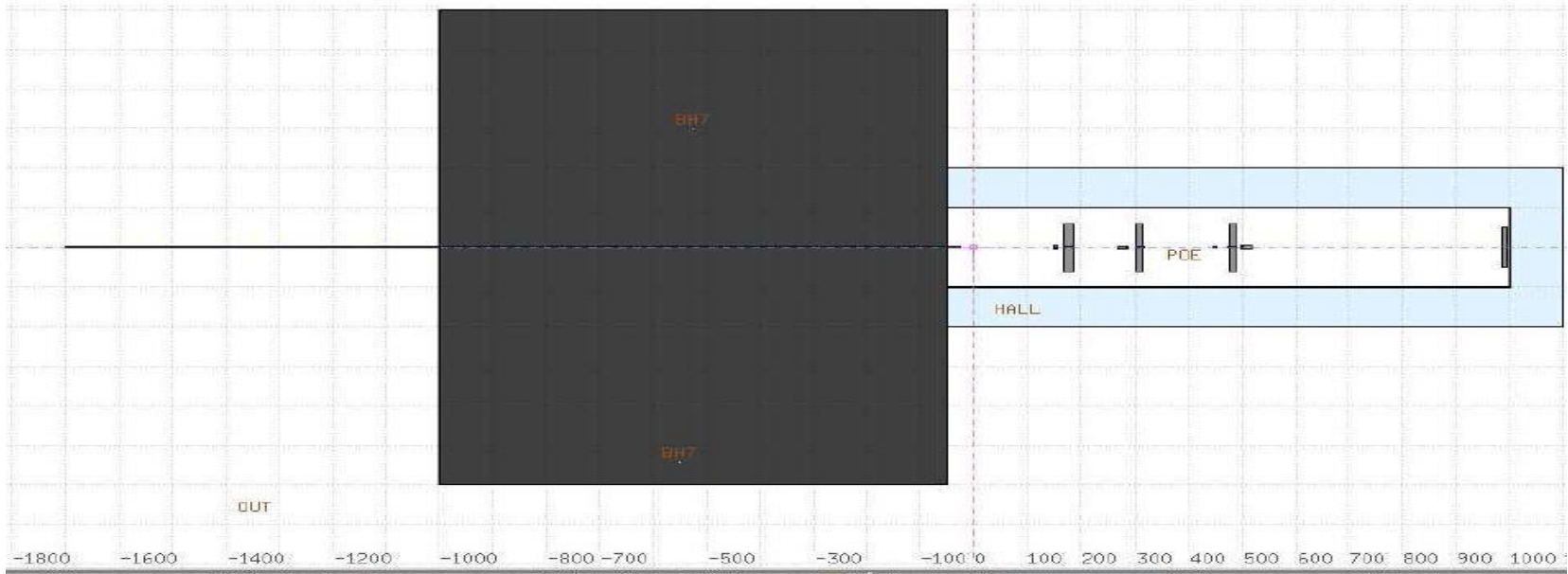
**Experimental**

Other issues (few words)





# Hutches order



# Shielding analysis results

## Front end safety stopper

Tungsten	18 cm
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## Optics (Pb)

Side wall	2.5 cm
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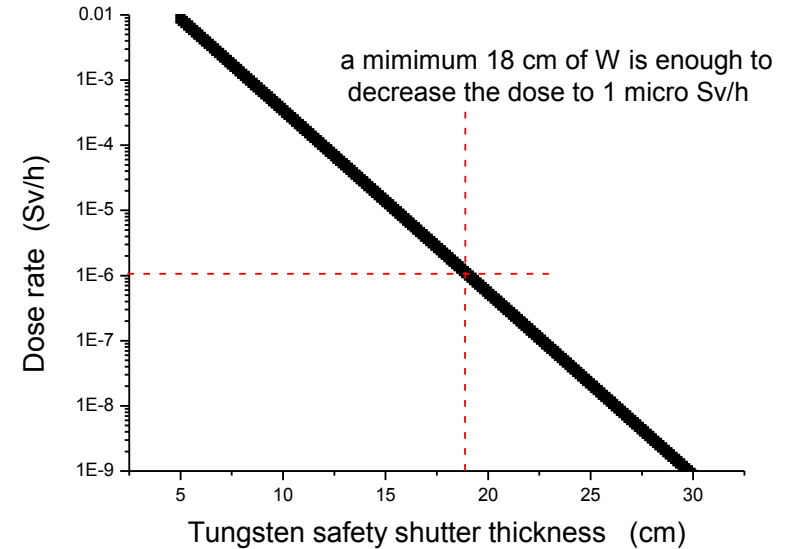
roof	1.5 cm
------	--------

Back wall	6.0 cm
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Additional 1 m <sup>2</sup>	10 cm
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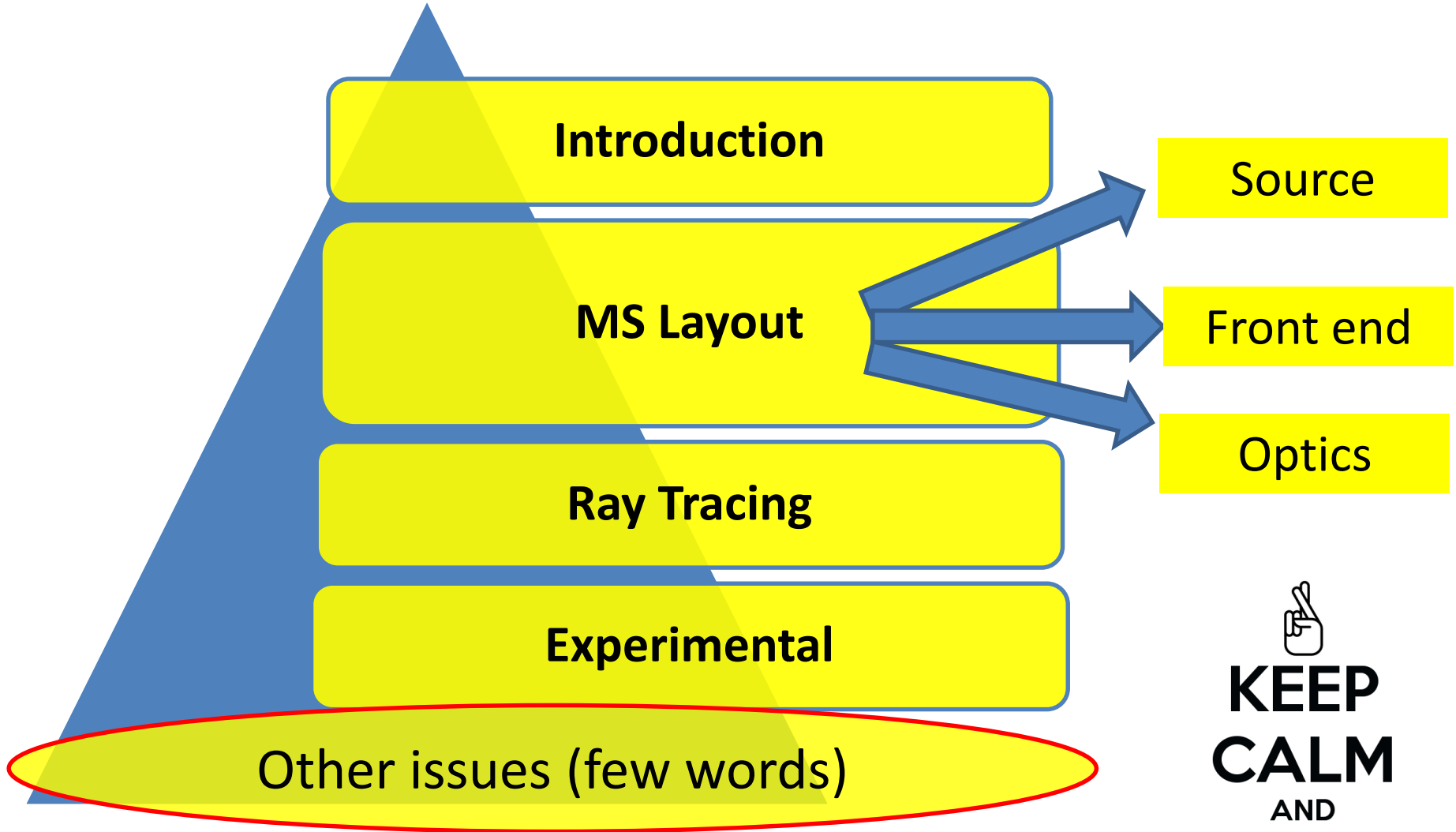
## Experimental (Pb)

All wall	0.5 cm
----------	--------



Other synchrotrons with comparable energies were considered also in the final decision

# Summery



**KEEP  
CALM  
AND  
CROSS  
FINGERS**

# Acknowledgments



Elettra Sincrotrone Trieste



UNIVERSITÀ DEGLI STUDI DI TRENTO

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e Ambientale

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# Some References

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- ❑ Fabia Gozzo; Non-conventional sources I: X-ray Powder Diffraction using Synchrotron Radiation; Summer School on Structure Determination from Powder Diffraction Data Paul Scherrer Institute, June 18th-22nd, 2008.
- ❑ F. Gozzo, B. Schmitt, Th. Bortolamedi, C. Giannini, A. Guagliardi, M. Lange, D. Meister, D. Maden, P. Willmott, B.D. Patterson; First experiments at the Swiss Light Source Materials Science beamline powder diffractometer; Journal of Alloys and Compounds 362 (2004) 206–217



$$flux\_at\_sample(E) = flux(E) \cdot Efficiency(E) = flux(E)^{SPECTRA} \cdot \frac{\Delta E_{SOURCE}}{0.001 \cdot E} \cdot Efficiency(E)$$

This quantity is expressed in photons/s. In our example we have the following values:

Energy	$\Delta E_{SOURCE}$	Efficiency	Flux Spectra (ph/s/0.1%BW)	Flux at sample (ph/s)
15000	20	0.04334	3.567e+14	2.02406e+13

